

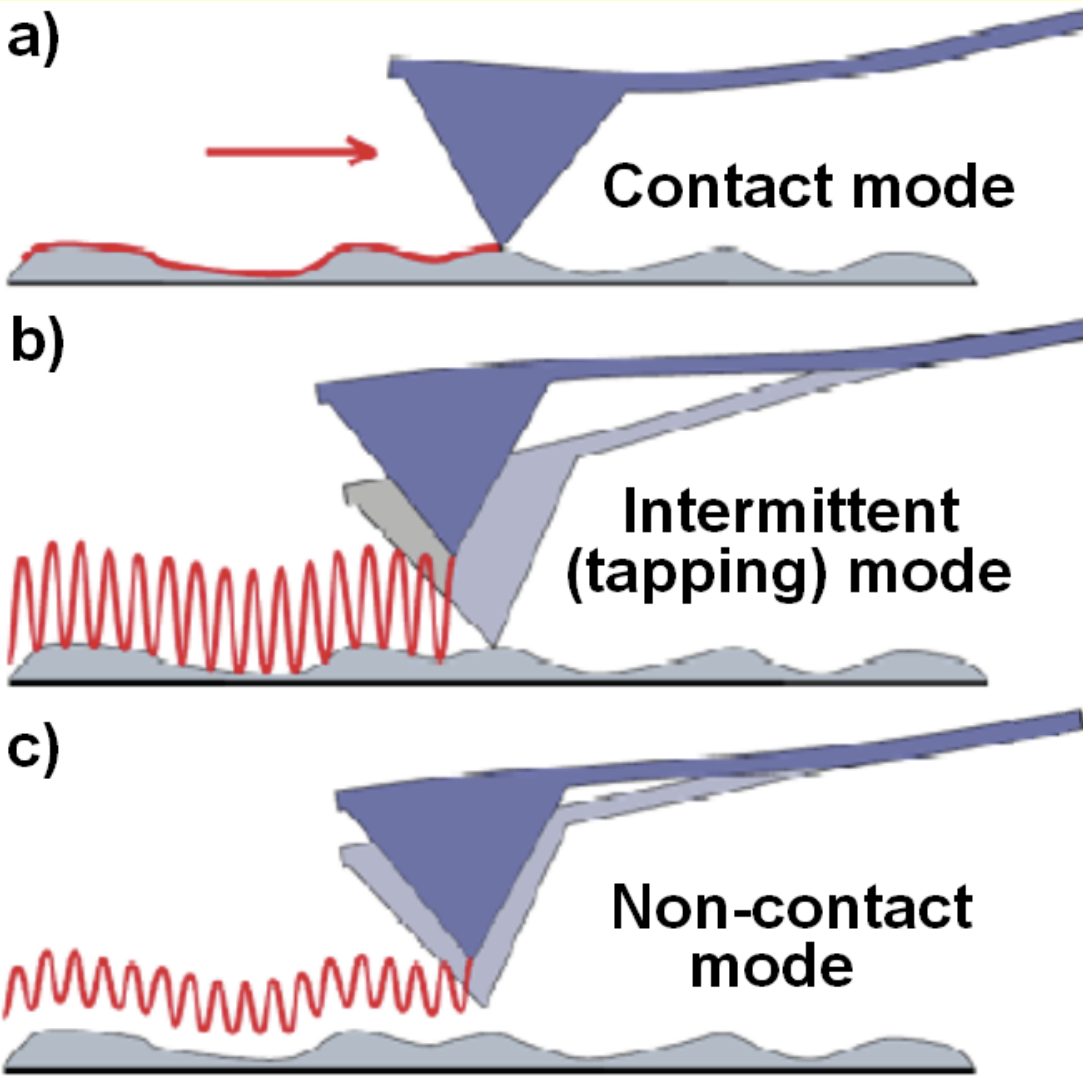
WHAT IS AFM-BASED NANOFABRICATION

- ◆ **Atomic Force Microscopy (AFM) -based nanofabrication is using a functionalized cantilevered-tip for performing nanofabrication.**
- ◆ **Nanofabrication aims at building nanoscale structures (0.1 – 100 nm), which can act as components, devices, or systems with desired properties, performance, reliability, reproducibility, in large quantities at low cost.**
 - **Methodology or Processing Technology**
 - **Toolbox (Equipment: hardware, software, system)**
 - **Nanostructured Materials or Raw Materials**
 - **Physical Product (Components, device, system....)**

AFM-Based Nanofabrication: Milestones

- **1982: Scanning Tunneling Microcopy (STM)** invented by Binnig, Rohrer, and Gerber (1986 Nobel Physics Prize).
- **1984: Scanning Near-Field Optical Microscopy (SNOM)** introduced by Pohl, Denk, Lanz, & Lewis, Isaacson, Harootunian, Muray.
- **1986: Atomic Force Microcopy** invented by Binnig (US Patent 4,724,318).
- **1990s: Lithography Using Scanning Tunnelling Micoscopy (STM) and AFM.**
- **2000s: Lithography Using (SNOM) and Deep Pen Nanofabrication (DPN).**
- **2008: APMC** (led by Zyvex Labs) **Awarded US\$9.7 Millions** by DARPA & Texas ETF for Commercialization of Tip Based Nannofabrication (TBN) (focusing on AFM).
- **2009/10 DOE Solicitation Upcoming.**
- **2009/10 NSF Solicitation Upcoming.**
- **2009-2013: \$100 million in 5 years in USA.**

Three Modes of Operation



- Contact mode: also known as static mode, an AFM tip makes soft "physical contact" with the sample. The tip is attached to the end of a cantilever with a low spring constant. The contact force causes the cantilever to bend to accommodate changes in topography.

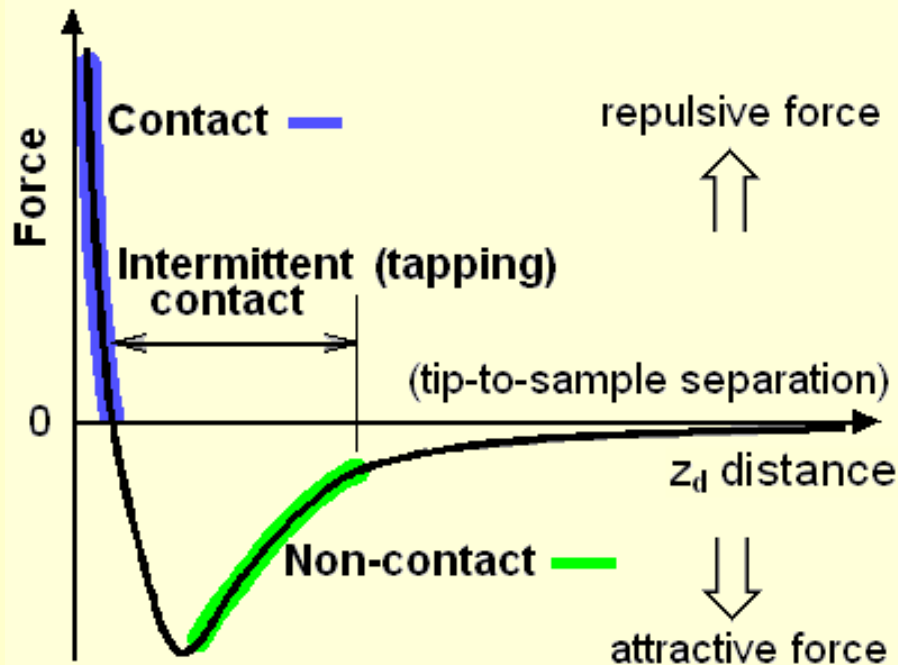
Measurement: **displacement** (δ)

Feedback signal: **force** (F) = $k\delta$

- Intermittent contact mode: also known as tapping mode, the cantilever is driven to oscillate up and down at near its resonance frequency by a small piezoelectric element mounted in the AFM tip holder. The amplitude of this oscillation is greater than 10 nm, typically 100 to 200 nm. A tapping AFM image is therefore produced by detecting the force of the oscillating contacts of the tip with the sample surface

Operation Modes and Van der Waals Curve

AFM can be operated in three different modes. Each mode is operated in a different level of Van der Waals force



Interatomic force versus distance

Operated at Frequency Modulation
or Amplitude Modulation

Measurement:

displacement, $\delta = \delta(t)$

Feedback signal:

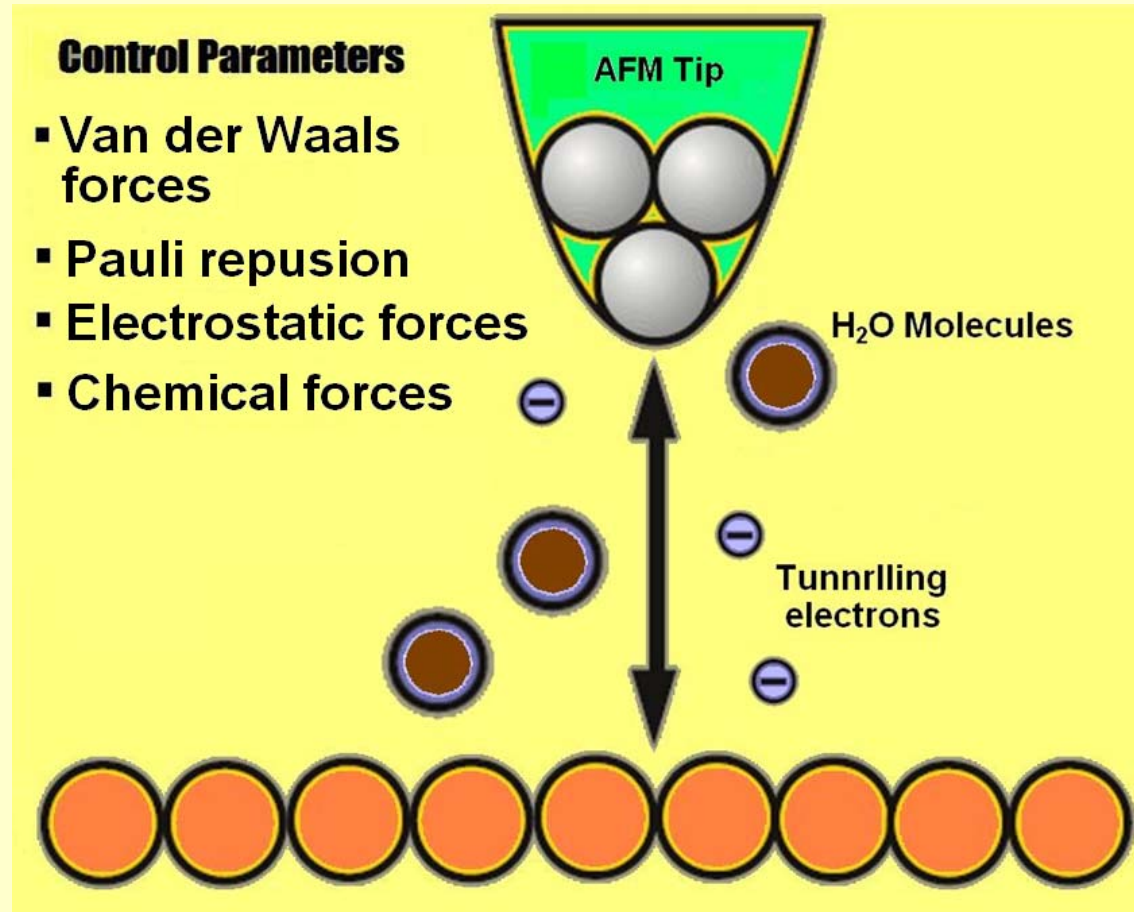
dynamic force, $F_d = F(k, \delta, t)$

- Non-contact (NC) mode: also known as dynamic mode, the cantilever is vibrated near but not contact to the sample surface at a frequency slightly above its resonance frequency (typically, 100 - 400 kHz) where its amplitude is typically a few nm. Due to interaction of forces acting on the cantilever when the tip comes close or taps to the surface (within 10 nm), Van der Waals force or other forces ($\sim 10^{12}$ N) act to decrease the resonance frequency of the cantilever. This decrease in resonance frequency combined with the feedback loop system maintains a constant oscillation amplitude or frequency by adjusting the average tip-to-sample distance. Measuring the tip-to-sample distance at each data point allows the scanning software to construct a topographic image of the sample surface. The absence of repulsive forces in NC mode permits its use in the imaging “soft” samples.

INTERACTION BETWEEN TIP AND SAMPLE

Presently AFM is loaded with forces and electric voltages in ambient environment

In addition to develop better instrumentation, the quantitative information on these controlling parameters is needed in almost all AFM patterning or lithography processes, including nanoscale manipulation, scratching, anodic oxidation, deep pen, near field and many other emerging techniques



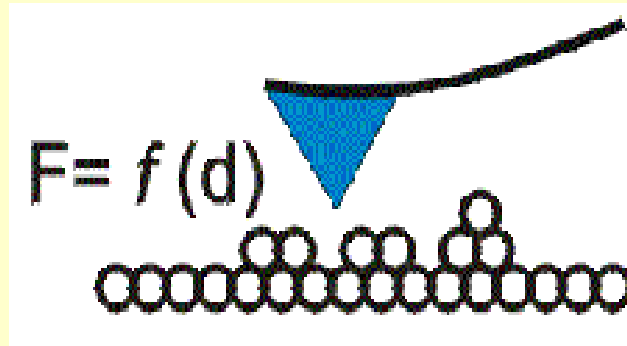
- To better perform AFM tasks
- To develop new AFM capabilities

TYPICAL ATOMIC FORCE MICROSCOPE

Digital Instruments Nanoscope IIIA

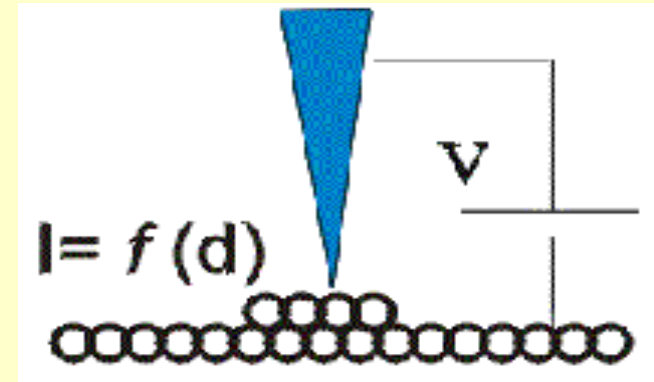


AFM: $d = \text{tip gap}$

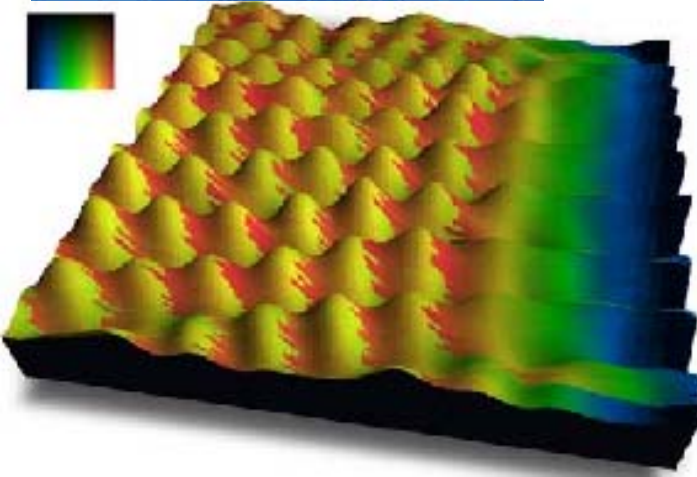


- Feedback signal is **Force (F)**
- Room environment
Low cost
- Cantilever provides
Dynamic mode

STM: $d = \text{tip gap}$

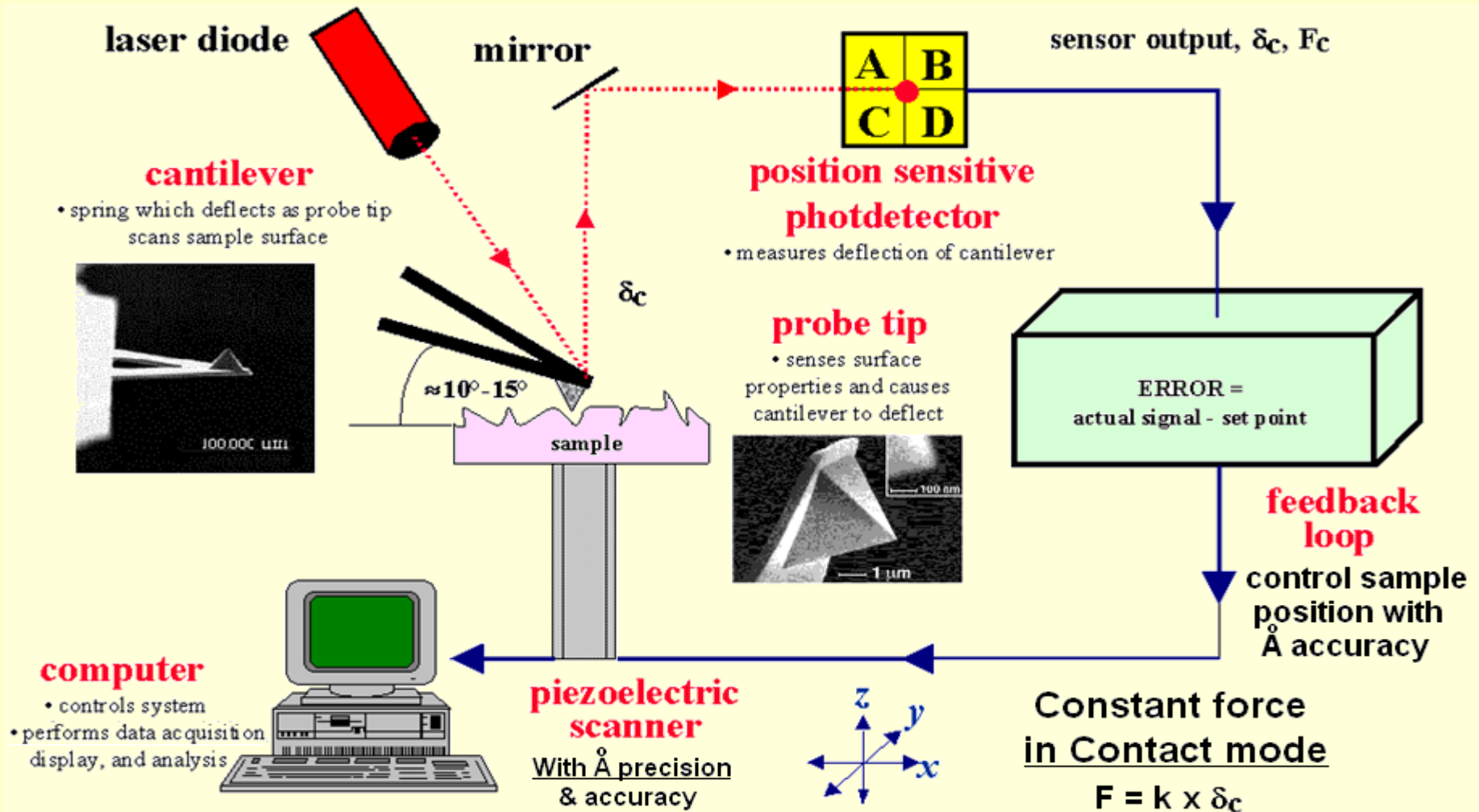


Feedback signal is
current (I)
Vacuum environment
High cost



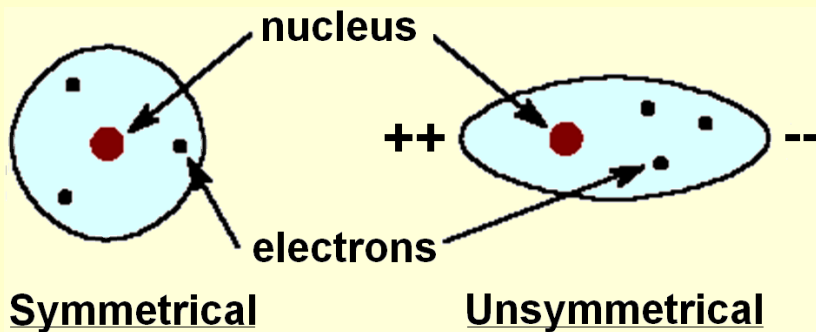
2.5 x 2.5 nm simultaneous topographic and friction image of highly oriented pyrolytic graphic (HOPG). The bumps represent the topographic atomic corrugation, while the coloring reflects the lateral forces on the tip. The scan direction was right to left

Atomic Force Microscope (AFM)



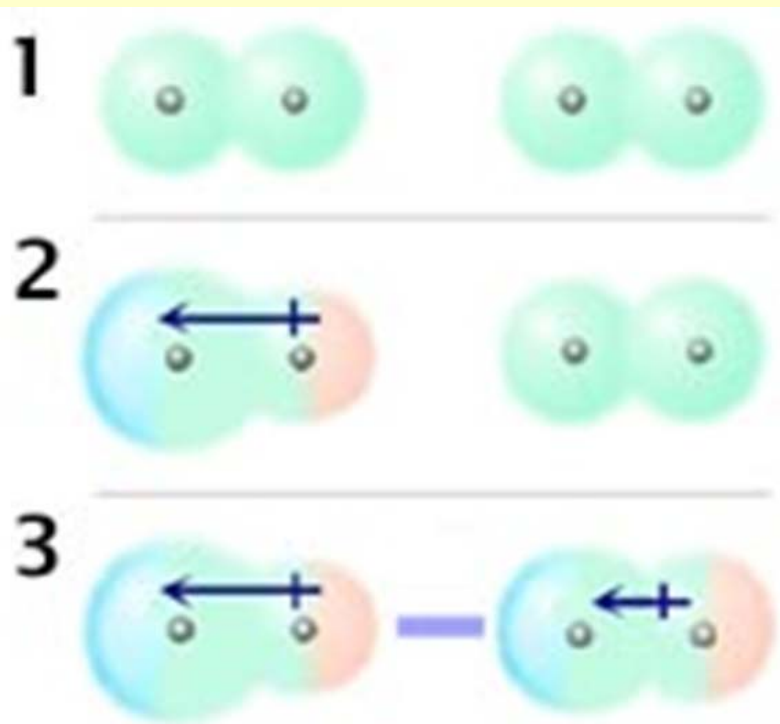
- The AFM combines the technology developed for the surface profiler with the scanning tunnelling microscope.
- AFM works on insulating materials and is the most widely used scanning probe microscope

Interaction Between Atoms or Molecules



London forces (van der Waals) arise from the temporary variations in electron density around atoms and non-polar molecules (1) depicts the average electron clouds of two nonpolar molecules. However at any *instant* the electron distribution around an atom or molecule will likely produce a dipole moment (2) which will average out to zero over a period of time. But even a temporary or transient dipole moment can induce a (temporary) dipole moment in any nearby molecules (3) causing them to be attracted to the first molecule.

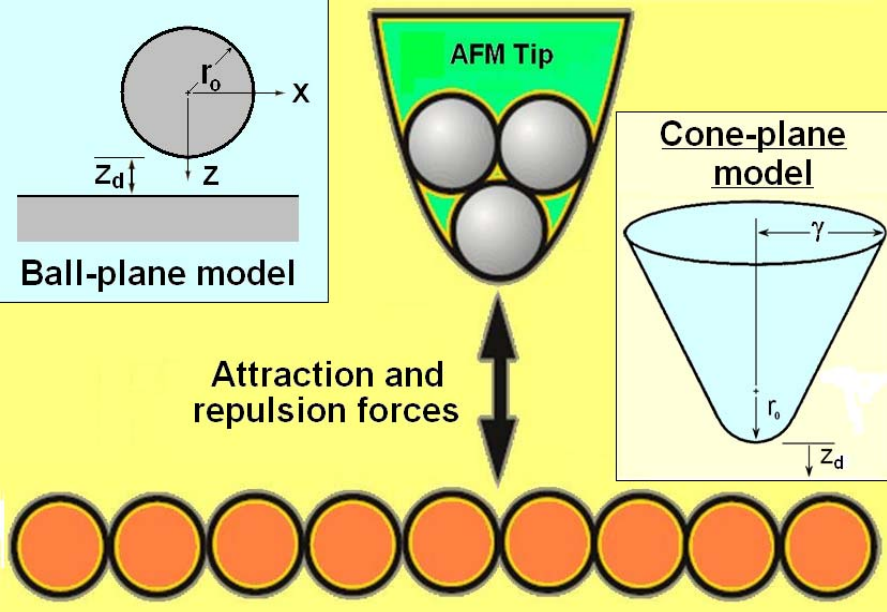
Atoms & Molecules



After discovered by Lord van der Waals, the vdW force was quantified by London (1930). The potential of the vdW interaction (p_v) can be approximated as

$$p_v(z) = -A_1 / z^6 \quad (1)$$

where A_1 is the interaction constant defined by London (1930) and dependent on the polarization and ionization potential associated and z is the distance between the centers of the paired atoms. In general, the above equation is effective only up to several tens nm. When the interactions are too far apart the dispersion potential, p_v , decays faster than $1/z^6$; this is called the retarded regime (Israelachvilli, 1991).



Hamaker (1937) performed the integration of the interaction potential of Eq. (1) to calculate the total interaction of the sphere-plane geometry. By assuming that the total interaction can be obtained by the pairwise summation of the individual contributions and the summation can be replaced by an integration over the volumes of the interacting elements with a uniform density of the plane, ρ_1 and the sphere, ρ_2 , the total potential for a sphere interacting with a smooth plane, P_v , should be

$$P_v(z) = -\rho_2 \rho_1 \int (A_1 / z^6) dV_1 dV_2$$

where V_1 and V_2 are the volume of the plane and sphere, respectively. If the distance between one element (dV_2) in the sphere and one element (dV_1) in the plane is $(x^2 + z^2)^{1/2}$ where dV_1 is located in a ring volume of $2\pi x dx dz$, the above equation, the above equation becomes

$$P_v(z) = -2\pi \rho_2 \rho_1 A_1 \int_0^\infty \int_0^\infty \int_0^\infty x / (x^2 + z^2)^3 dx dz dV_2 = -\frac{2\pi \rho_1 \rho_2}{12} \int z^{-3} dV_2$$

By considering a circular section of area $(\pi x^2 dz')$, where z' varies from 0 to r_o , the integration of the whole sphere interaction with the plane can be found. Since $x^2 = r_o^2 - z'^2$ and $z = z' + z_d$ the above equation becomes

$$P_v(z', z_d) = -\frac{\pi \rho_1 \rho_2 A_1}{6} \int_{-r_o}^{r_o} \pi [(r_o^2 - z'^2) / (z' + z_d)^3] dz' = -\frac{A_h r_o}{6 z_d} \left[1 + \frac{z_d}{2 r_o + z_d} + \dots \right]$$

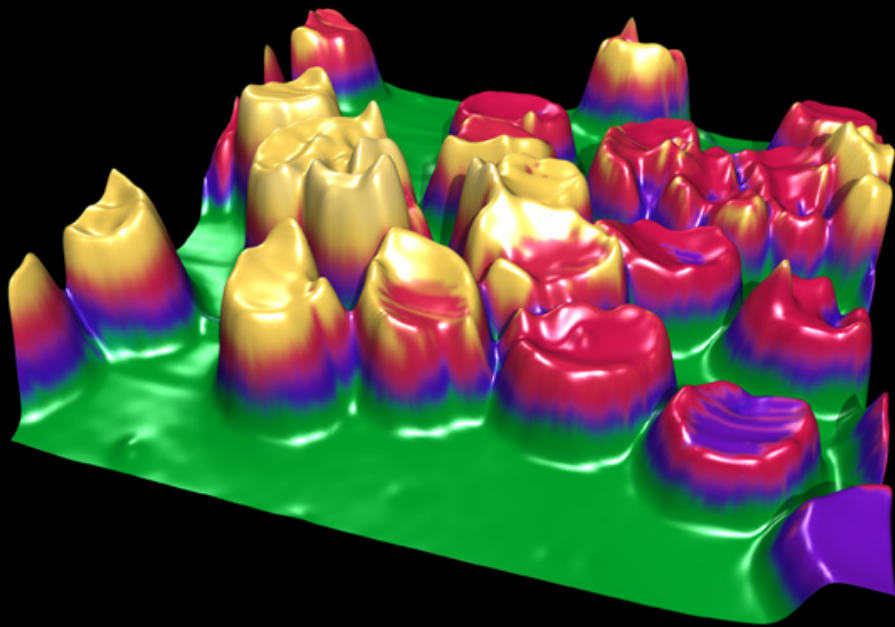
Since the associated vdW force (F_v) can be found to be the gradient of that potential, i.e $F_v = -\nabla P_v(z_d)$

$$F_v(z_d) = -\frac{A_h r_o^3}{3 z_d^2 (z_d + 2 r_o)^2}$$

If $z_d \ll r_o$, the above equation can be reduced to

$$F_v(z_d) = -A_h r_o / (6 z_d^2)$$

where A_h is the well-known Hamaker constant equal to $A_1 \pi^2 \rho_1 \rho_2$.

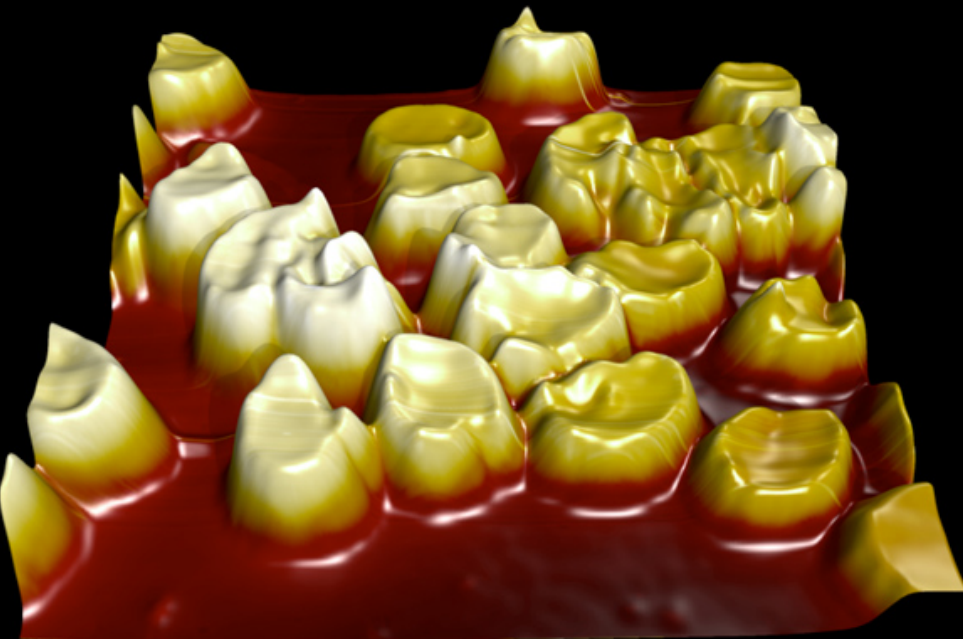


AFM HEIGHT IMAGES

Using Non-contact
mode for soft materials

Topographical 3D
Rendering of Red
Blood Cells. Raw
atomic force
microscope data is
visualized as 3D
surface

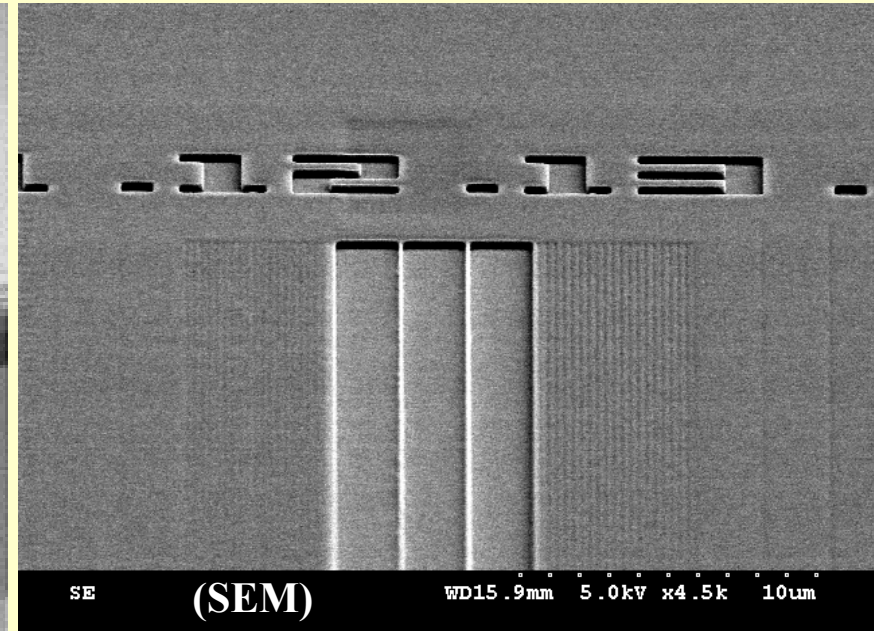
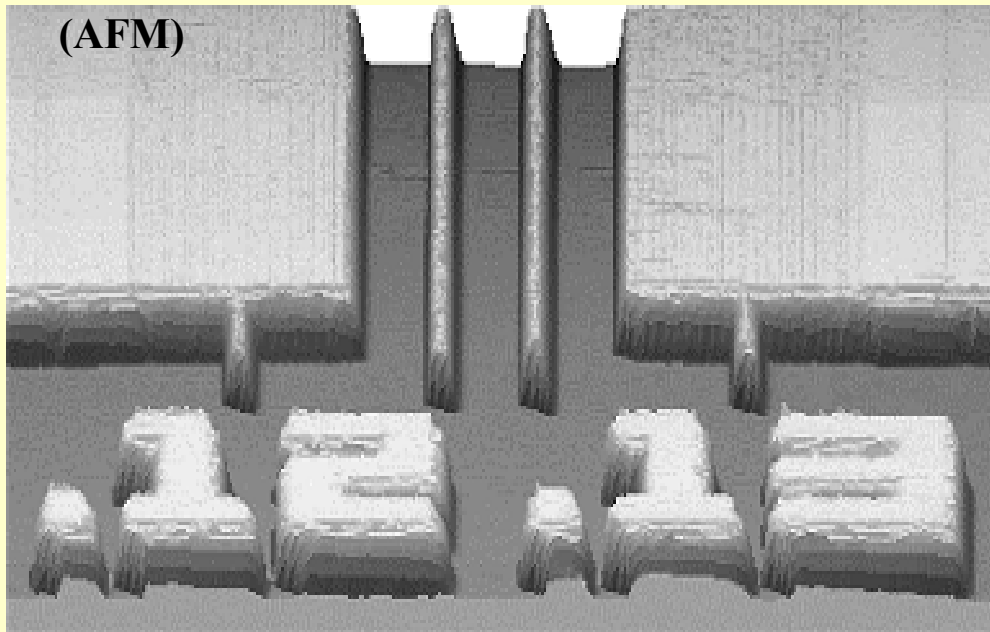
Data by Janelle Gunther, 3D Rendering by Ben Grosser (in
www.itg.uiuc.edu/exhibits/gallery)



Comparison of Three Modes of Operations

	Advantage	Disadvantage
Contact Mode	<ul style="list-style-type: none">• High scan speeds• Rough samples with extreme changes in vertical topography can sometimes be scanned more easily	<ul style="list-style-type: none">• Lateral (shear) forces may distort features in the image• In ambient conditions may get strong capillary forces due to adsorbed fluid layer• Combination of lateral and strong normal forces reduce resolution and mean that the tip may damage the sample, or vice versa
Tapping Mode	<ul style="list-style-type: none">• Lateral forces almost eliminated• Higher lateral resolution on most samples• Lower forces so less damage to soft samples or tips	<ul style="list-style-type: none">• Slower scan speed than in contact mode
Non-contact Mode	<ul style="list-style-type: none">• Both normal and lateral forces are minimised, so good for measurement of very soft samples• Can get atomic resolution in a UHV environment	<ul style="list-style-type: none">• In ambient conditions the adsorbed fluid layer may be too thick for effective measurements• Slower scan speed than tapping and contact modes to avoid contacting the adsorbed fluid layer

IMAGING COMPARISON OF AFM AND SEM



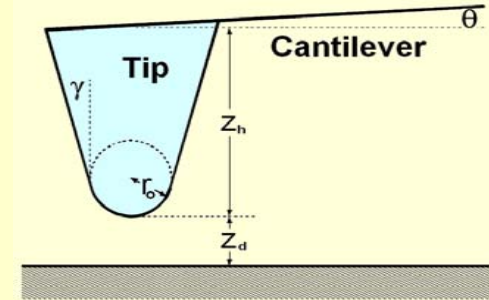
Atomic Force Microscopy

- Contrast on flat samples
- 3D magnification
- Works in ambient air

Scanning Electron Microscopy

- Good depth of field
- Fast scanning
- 2 $\frac{1}{3}$ D magnification

Electrostatic Potential and Forces



- The Lennard-Jones potential is important for the interaction between **neutral** atoms or molecules. The electrostatic interaction force becomes important, if the particles are **electrically charged** and conductive.

- Frequently, in calculating the interaction forces, the molecules with permanent dipoles can be treated as point charges.

- An appropriate understanding of electrostatic forces is of a wide interest for better controlling the **electromagnetic induced reactions** and the related charging mechanisms in performing many AFM-based nanopatterning processes, such as local anodic oxidation and electrostatic nanolithography as well as Kelvin probe microscopy.

- The electrostatic potential (p_e), also known as **Coulomb potential**, is an effective pair potential that describes the interaction between two point charges. It acts along the line connecting the two charges (q_1, q_2):

$$p_e = \frac{q_1 q_2}{4\pi\epsilon_0 r}$$

where r is the distance between two charges and ϵ_0 is the electric constant (permittivity of free space).

B.M. Law, F. Rieutord, Phys. Rev. B 66 (2002) 035402; S. Watanabe, K. Hane, T. Ohye, M. Ito, T. Goto, J. Vac. Sci. Technol. B 11 (1993) 1774.; C. Bohm, C. Roths, U. Müller, A. Beyer, E. Kubalek, Mater. Sci. Eng. B 24 (1994).

The corresponding **Coulomb force** (F_e) between two charges can be found as:

$$F_e = \frac{-q_1 q_2}{4\pi\epsilon_0 r^2}$$

The total interaction force can be found by integrating all charged particles involved. Analytical integration solutions do exist for very limited simple cases. The formula developed by Law and Rieutord (2002) for a conical tip with a spherical apex of r_0 and a rectangular include angle, θ is selected:

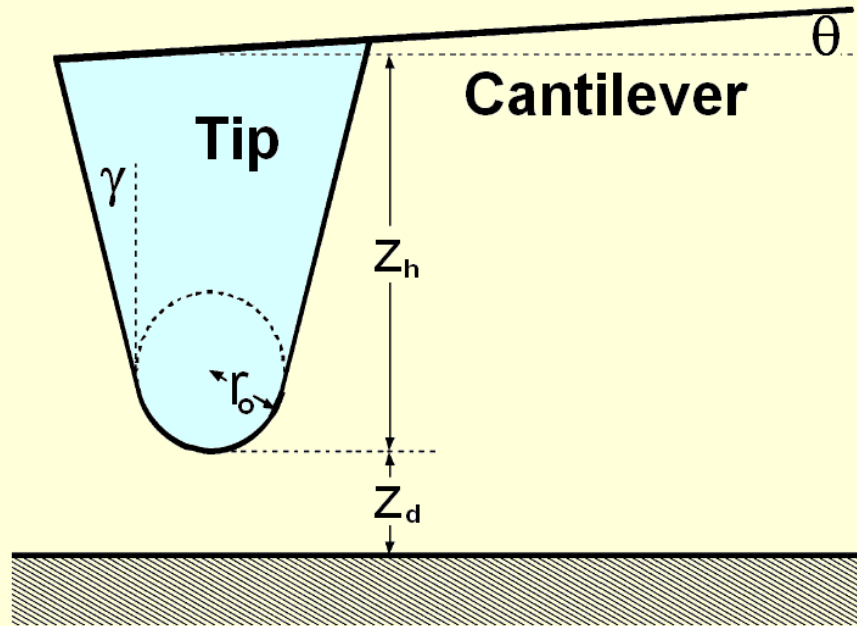
$$F_e = \pi\epsilon_0 V^2 z(z_d)$$

where V is the applied voltage and $z(z_d)$ is a geometrical function including the contributions from the spherical apex and conical part of the tip and the cantilever (as shown in the attached figure). By assuming $\theta = 0$, an approximation for $z(z_d)$ adopted by Butt et al. (2005) can be applied here. Then, the electrostatic force becomes:

$$F_e = \pi\epsilon_0 \frac{r_0^2 V^2}{z_d (z_d + r_0)}$$

If $\theta \gg 0$, a more complicated solution is needed. Numerical solutions for non-simplified geometries reported by Watanabe, et al. (1993) and Bohm et al. (1994) can also be used for the present electrostatic force calculation.

Electrostatic Potential and Forces

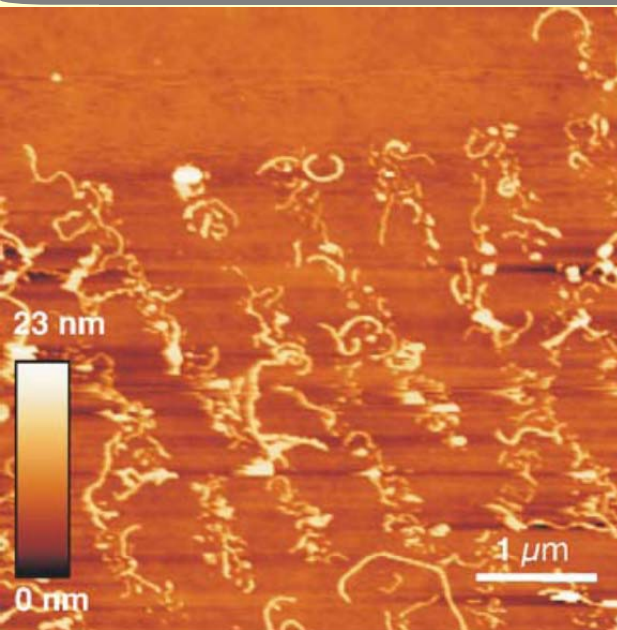


For good conductors, the electric potential is identical to the applied potential. In a calculation that implies that the field lines are oriented perpendicular to the surfaces. The induced capacitance, C , can also be used to estimate the electrostatic forces involved. A calculation of the electrostatic force is given by

$$F_e(z) = -\frac{dC}{2dz}V^2$$

where C is the capacitance of tip and sample and V is the applied voltage. To precisely evaluate the capacitance variation, numerical techniques are normally used.

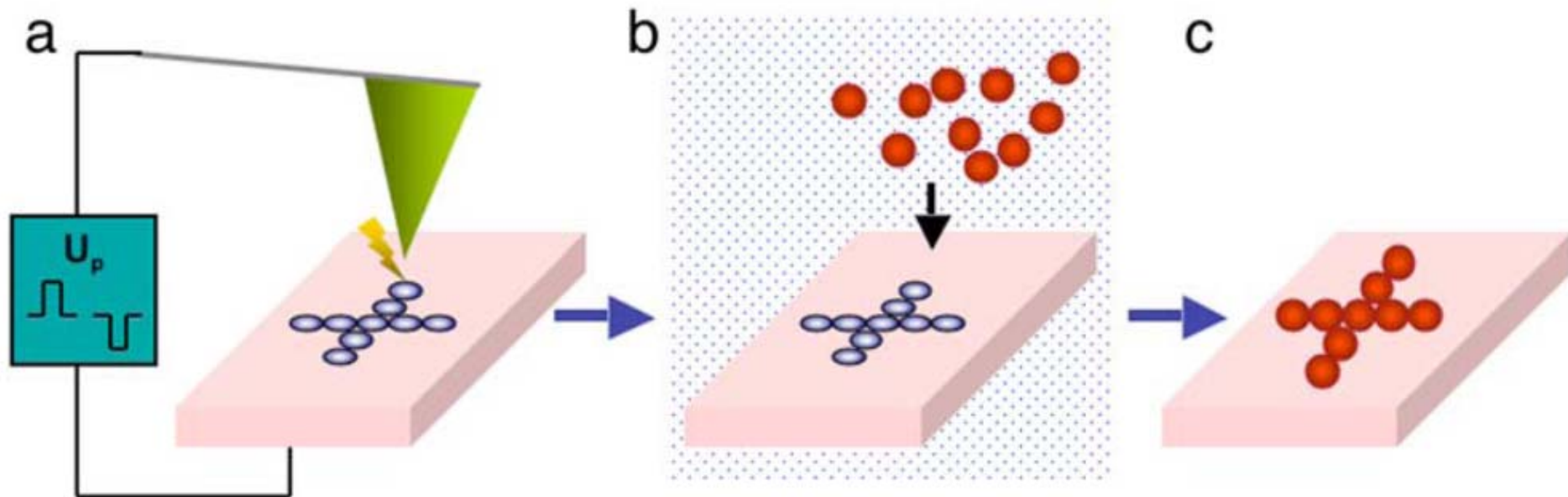
Electrostatic Patterning: Nano-Xerography



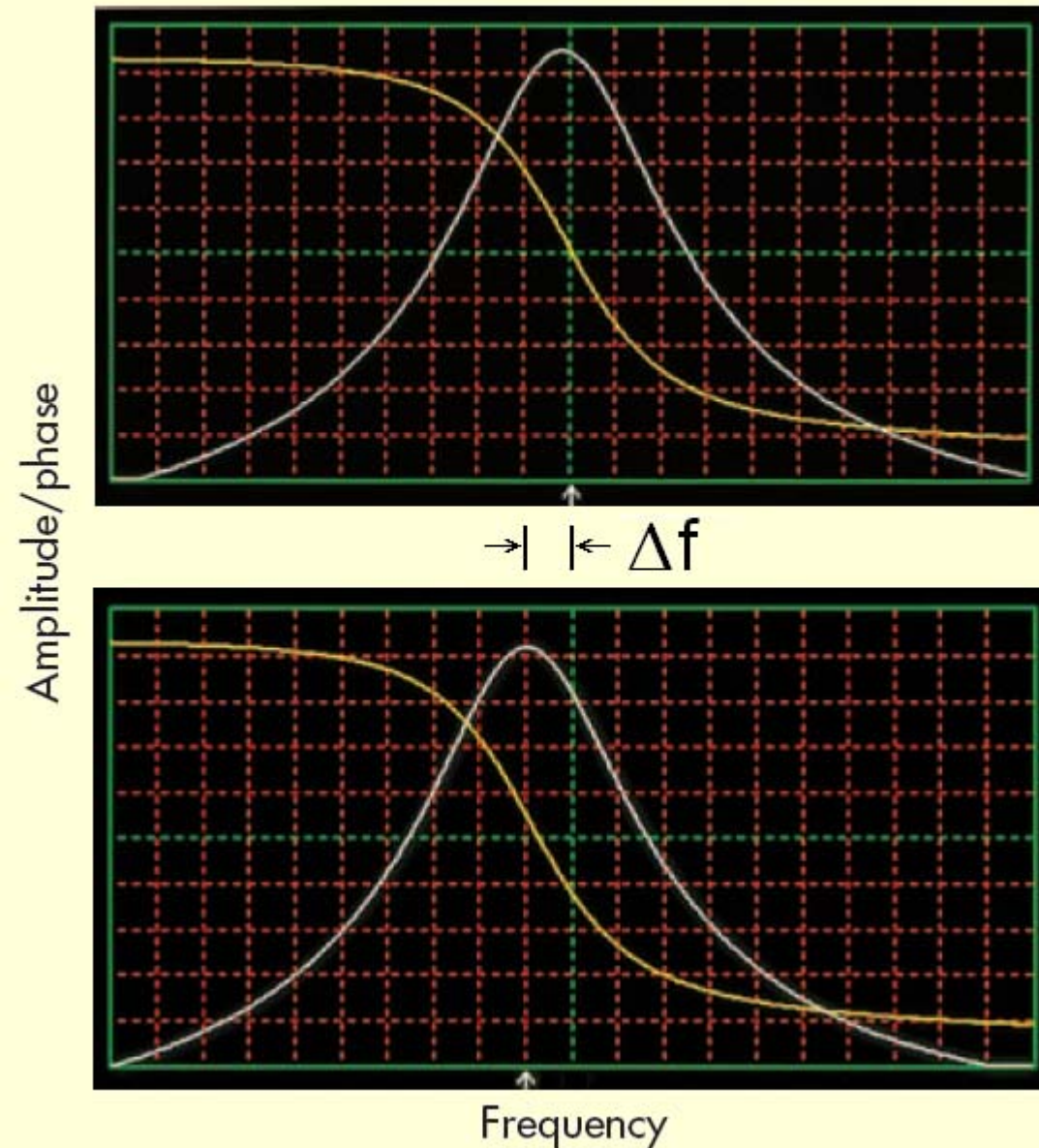
Nano-xerography of carboxyl functionalized multiwalled carbon nanotubes.

A Stemmer, D Ziegler, L Seemann, J Rycken N Naujoks, J. Physics: Conference Series 142 (2008) 012048

Nano-xerography: (a) Charge patterns are written into an electret layer on a solid substrate by applying voltage pulses to a conductive AFM tip. (b) The sample is developed in a suspension of nano-objects. (c) After rinsing and drying, the nano-objects remain selectively attached to the predefined pattern.

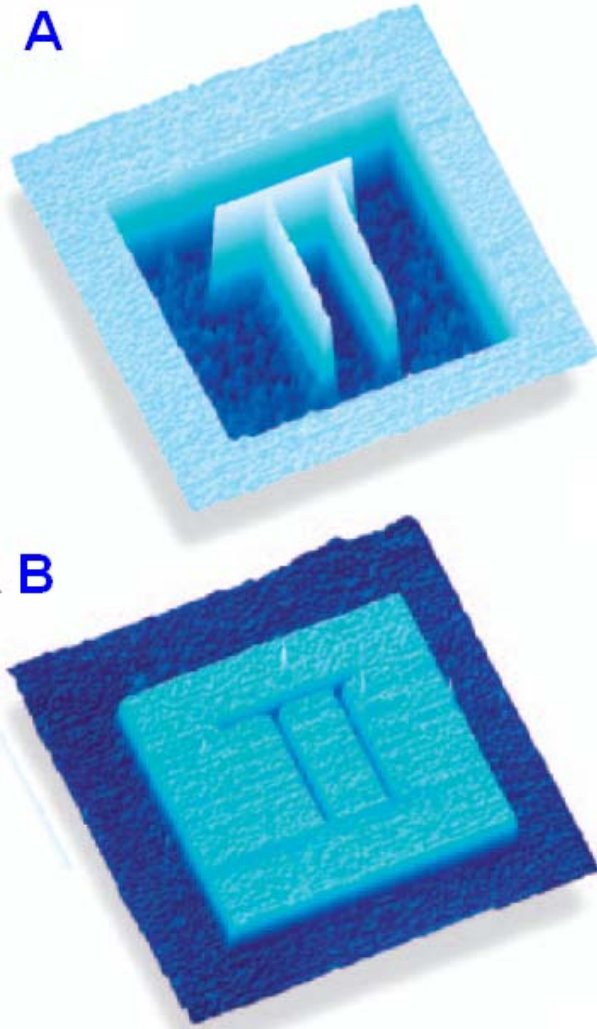


Resonance Shift by Electrostatic (Coulomb) Force

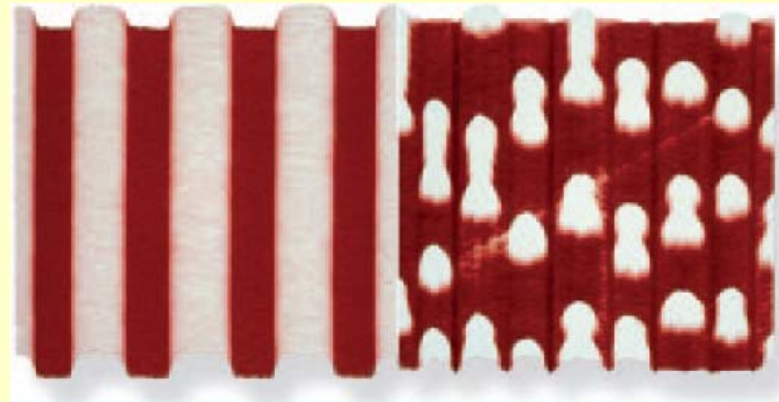


A conductive AFM tip can interact with the sample through long-range Coulomb forces: Amplitude (white) and phase (yellow) resonance response of a metal-coated AFM cantilever/tip above a sample of aluminum, held at 0V (top) and 10V (bottom) relative to the grounded tip. The tip is never in contact with the sample. In the presence of the electric field (bottom plot), the tip experiences an attractive force toward the sample. Effectively, the stiffness (spring constant) and thus the resonance frequency of the cantilever is reduced; the entire resonance curve shifts down along the frequency axis (horizontal). Changes in the cantilever's amplitude and phase are used to characterize electrical properties on, or just beneath, the surface of the sample.

Electric & Magnetic Forces Map by AFM

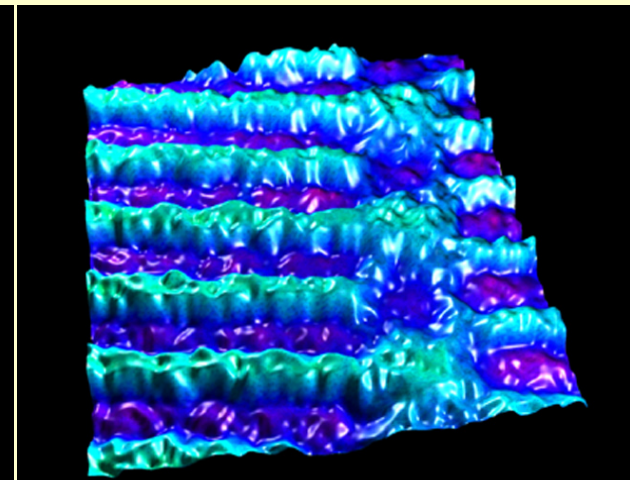
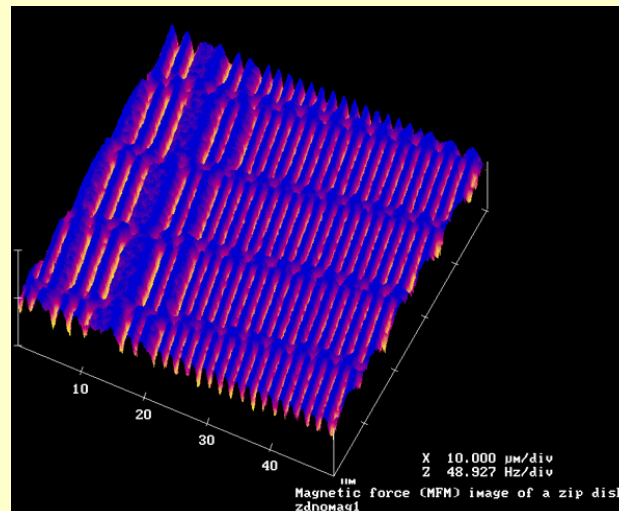


15μm scan Electric Force images showing reversed tip bias from A to B of polarized ferroelectric domains in an epitaxial, single crystalline $\text{Pb}(\text{Zr}_{0.2}\text{Ti}_{0.8})\text{O}_3$ thin film. The polarization pattern was created using the same metal-coated AFM tip that moments later captured these images (corresponding topography is featureless (not shown), with 0.2nm RMS roughness). Courtesy of T. Tybell, C.H. Ahn, and J.M. Triscone,

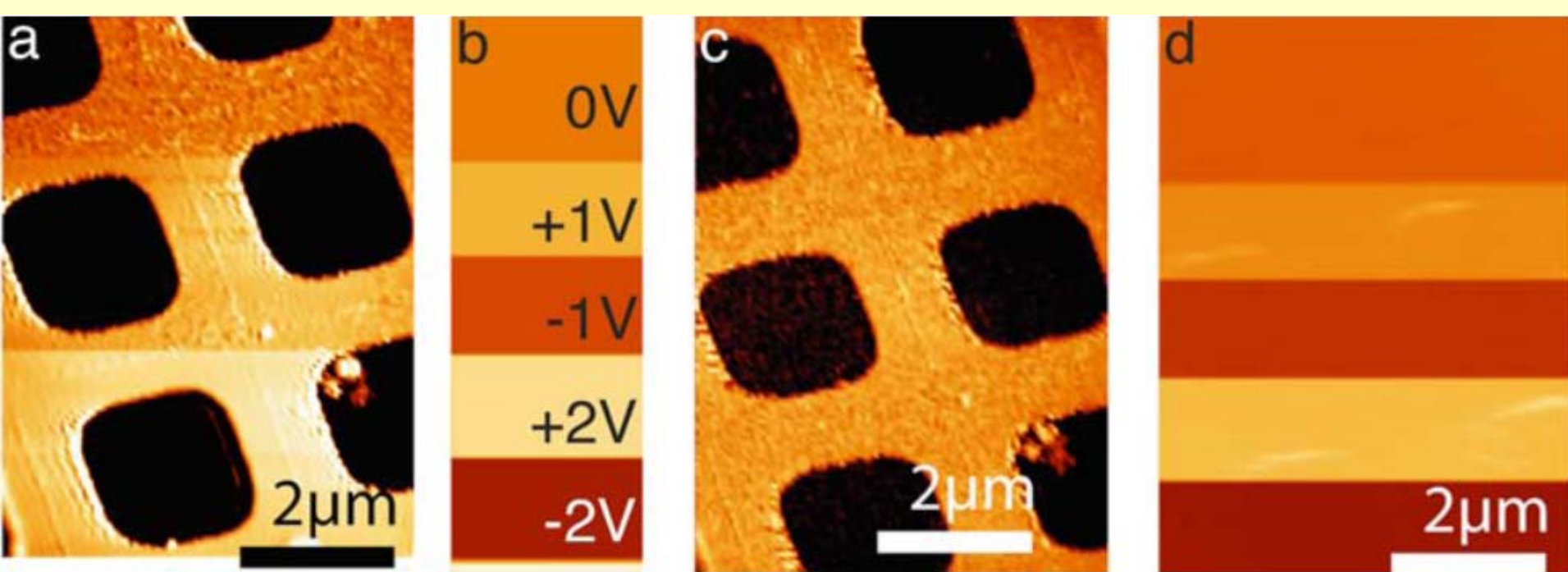


Topography (left) & Surface Potential (right) images of a CD-RW. SP image locates the position of the bits. Courtesy of Yasudo Ichikawa,

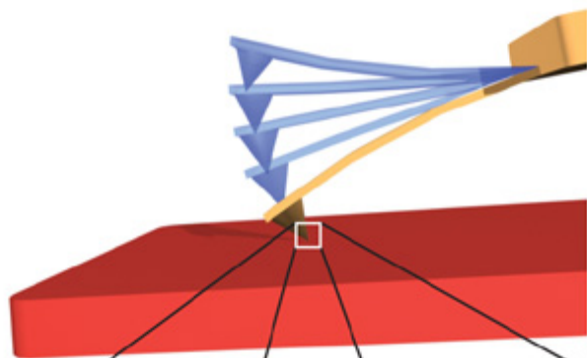
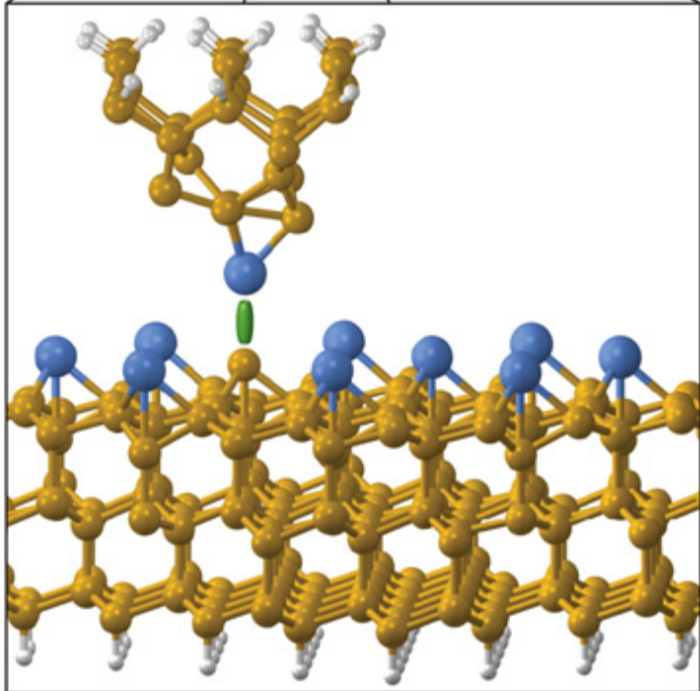
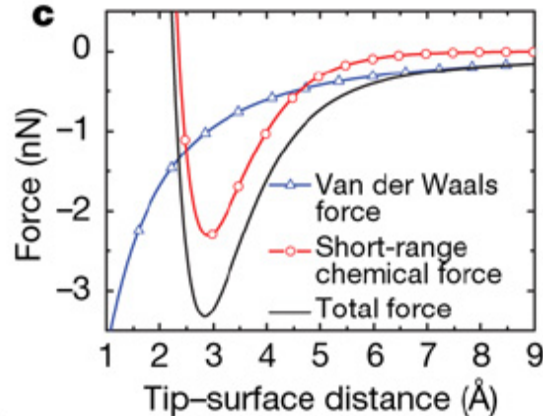
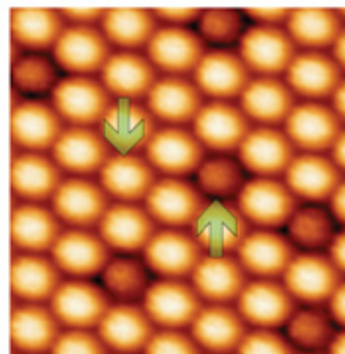
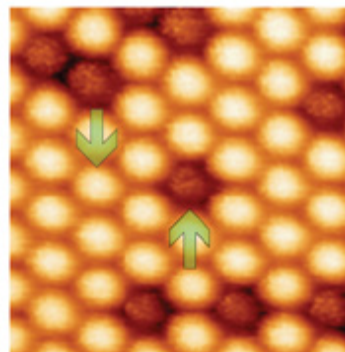
Magnetic Force Map of Surface of Zip Disk



Effect of Electrostatic Forces in Topography Measurements



Compensation of electrostatic forces leads to true topography measurements in tapping mode atomic force microscopy. Topography (a) of a gold-coated silicon grating showing height offsets when forces due to an externally applied bias voltage (b) are not compensated. True topography (c) when electrostatic forces are compensated locally by applying a voltage corresponding to the measured surface potential (d).

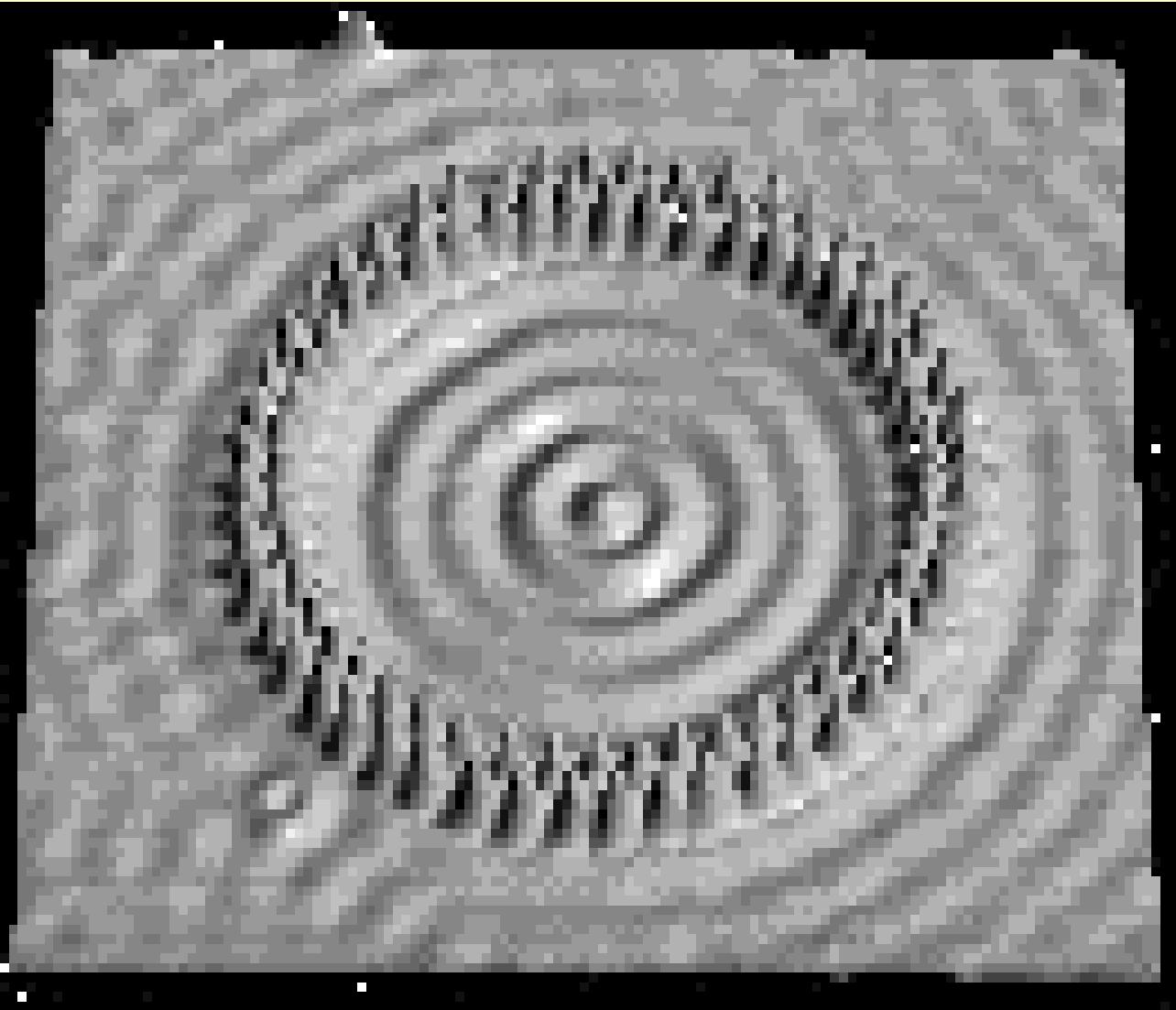
a**b****c****d****e**

AFM Operation In Dynamic Mode

(a), and of the onset of the chemical bonding between the outermost tip atom and a surface atom (highlighted by the green stick) that gives rise to the atomic contrast (b). However, the tip experiences not only the short-range force associated with this chemical interaction, but also long-range force contributions that arise from van der Waals and electrostatic interactions between tip and surface (though the effect of the latter is usually minimized through appropriate choice of the experimental set-up). c) Curves obtained with analytical expressions for the van der Waals force, the short-range chemical interaction force, and the total force to illustrate their dependence on the absolute tip-surface distance.

d–e), Dynamic force microscopy topographic images of a single-atomic layer of Sn (d) and Pb (e) grown, respectively, over a Si(111) substrate. At these surfaces, a small concentration of substitutional Si defects, characterized by a diminished topographic contrast, is usually found. The green arrows indicate atomic positions where force spectroscopic measurements were performed. Image dimensions are (4.3 4.3) nm²; for the acquisition parameters (Sugimoto et al., Nature 2007).

From Atomic **Imager** To Nanoscale **Manipulator**



**Electron
waves on a
metal
surface and
quantum
corrals:
Iron on
Copper
(111)**

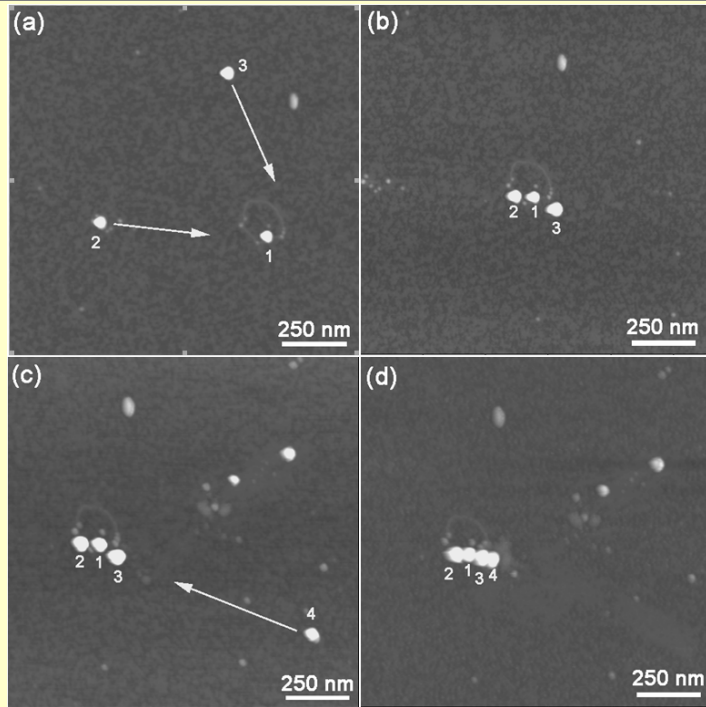
Crommie, et al. (1995)

Milestones in Atomic Characterization and Manipulation

- **1986: Atomic Force Microcopy invented by Binnig** (US Patent 4,724,318)
- **1987: AFM with vibrated cantilever** (Martin, Willams, Wickramasinghe, J. Appl Phys)
- **1991: Single Xe atoms positioned on Ni (110) surface*** (Eigler, Schweizer, [Nature](#))
- **1993: Quantum confined structures built*** (Crommie, Lutz, Eigler, [Science](#))
- **1999: Magnetic nanostructures built*** (Chen, Jamneala, Madhavan, Crommie, [Phys. Rev](#))
- **1999: Single bonds characterization*** (Lee, Ho, [Science](#))
- **2000: Artificial molecules built*** (Hla, Bartels, Meyer, Rieder, [Phys. Rev. Lett](#))
- **2000: Atomic chemical reaction*** (Hla, et al., [Phys. Rev. Lett](#))
- **2002: Atomic wire built*** (Nilius, Wallis, Ho, [Science](#))
- **2002: Molecular computation: molecular cascades*** (Heinrich, Lutz, Gupta, Eigler, [Science](#))
- **2003: Single molecule device*** (Nilius, Qiu, Ho, [Science](#))
- **2004: Single molecule doping*** (Yamachika, et al., [Science](#))
- **2005: Moving atom at room temperature by AFM** (Sugimoto, et al., [Nature Mater](#))
- **2007: Chemical identification of single atoms by AFM** (Sugimoto, et al., [Nature](#))
- **2008: Force measurements in moving atoms by AFM** (Ternes, et al., [Science](#))
- **2009: Quantum confinement of electrons in 3D*** (Moon et al., [Nature Nanotech](#))

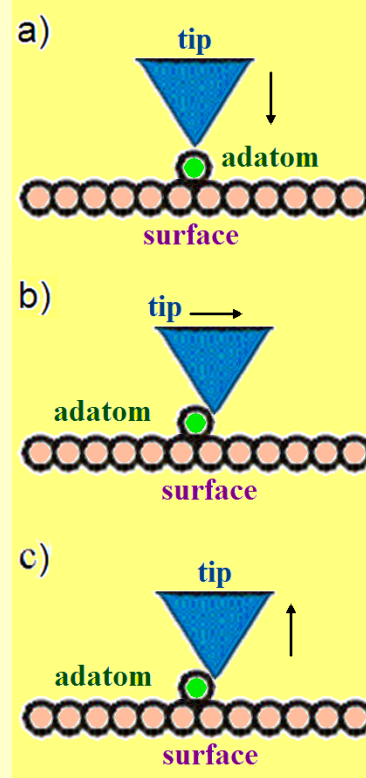
*by STM

Nanomanipulation



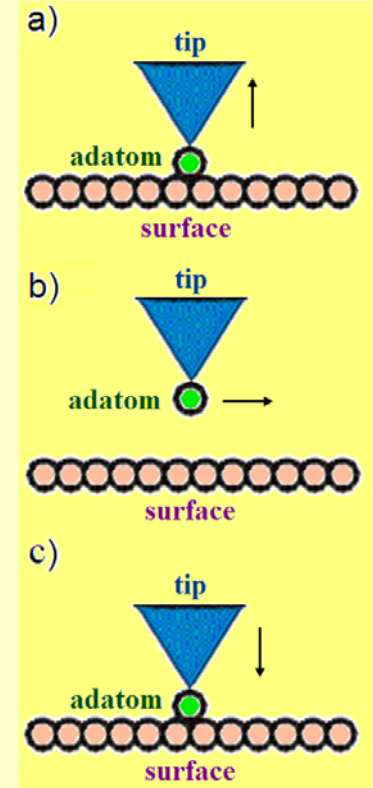
AFM images of lateral manipulation of 24-nm Au nanoparticles to create chain-like nanostructure by FM-AFM: a) pushing nanoparticles labeled with 2 and 3 along direction shown by arrows, b) nanoparticles 2 and 3 are pushed close to nanoparticle 1, c) moving nanoparticle 4 towards nanoparticle 1, d) final chain-like nanostructure

Lateral Manipulation

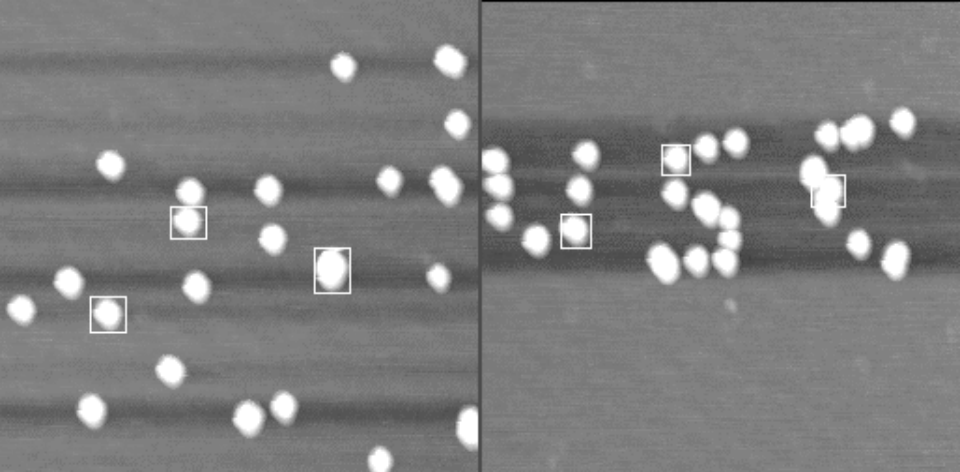


Adatom remains bound to surface and pushed or dragged by tip: a) pulling where adatom discontinuously follows tip from one adsorption site to another due to attractive forces, b) sliding where adatom is trapped under tip and follows its motion instantaneously and continuously, c) tip is retracted at desired place.

Vertical manipulation



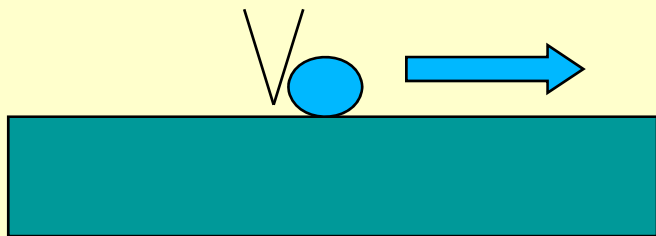
Adatom is transferred from surface to STM tip and back to surface: a) tip picking adatom from adsorption site and adatom dissociation occurring, b) tip lifting adatom from surface and moving to desired place due to attractive forces, c) tip with adatom is loaded at desired site.



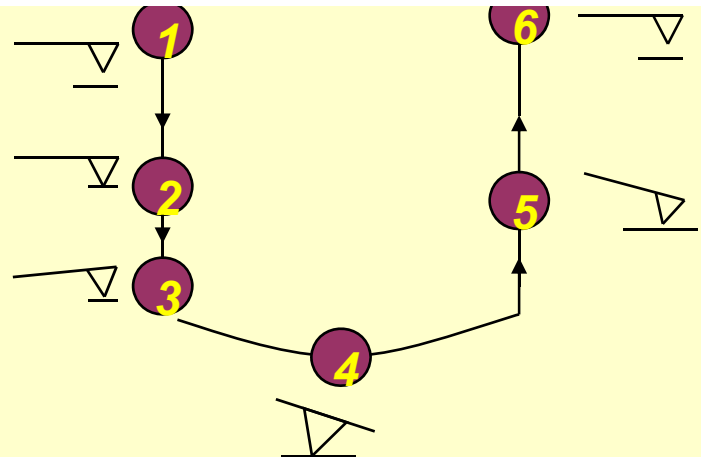
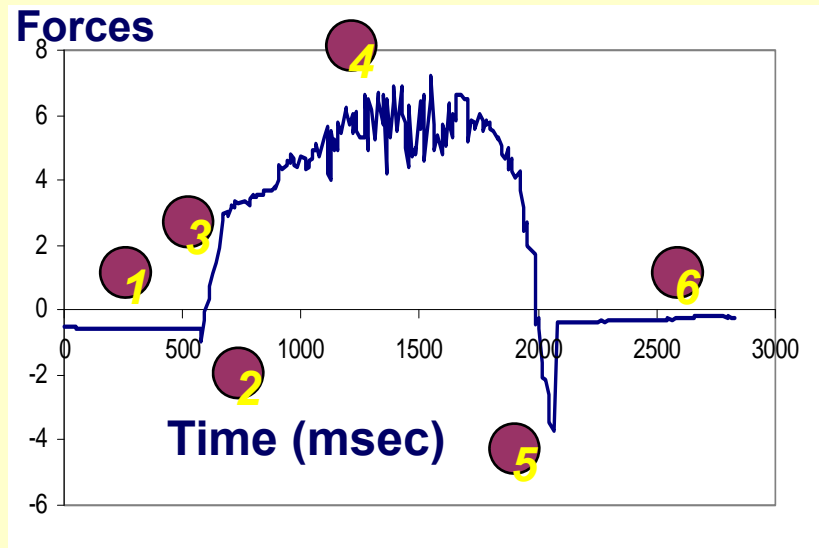
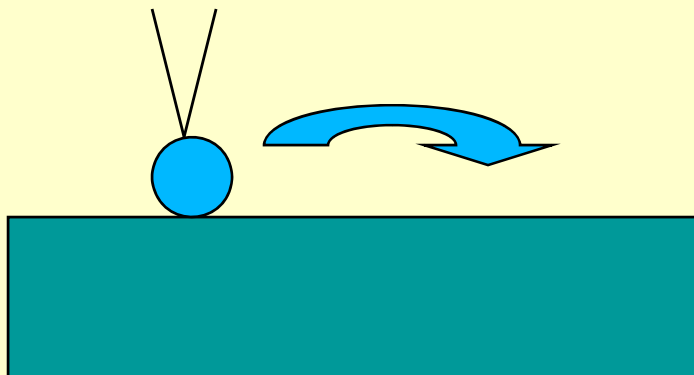
Nanoscale Manipulation

(Bottom-up)

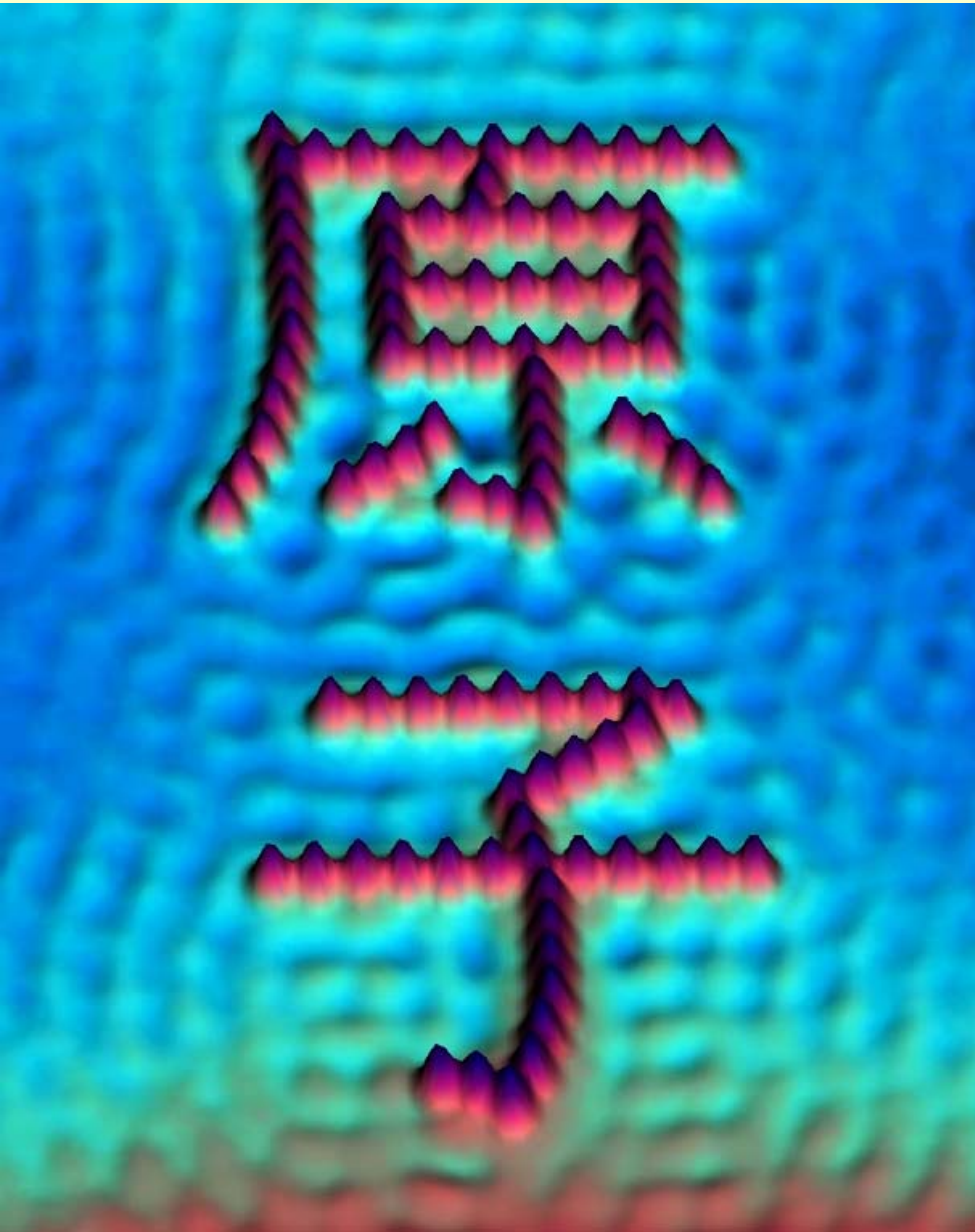
Push Objects



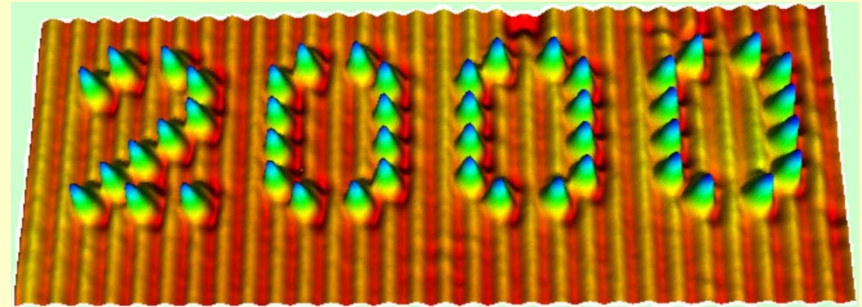
Lift-Drop



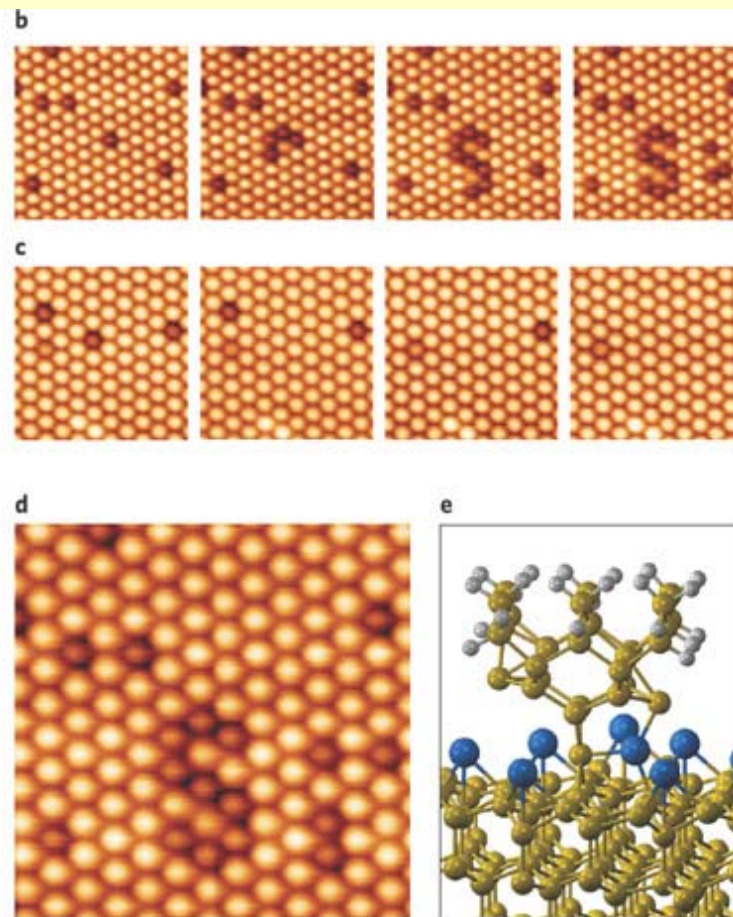
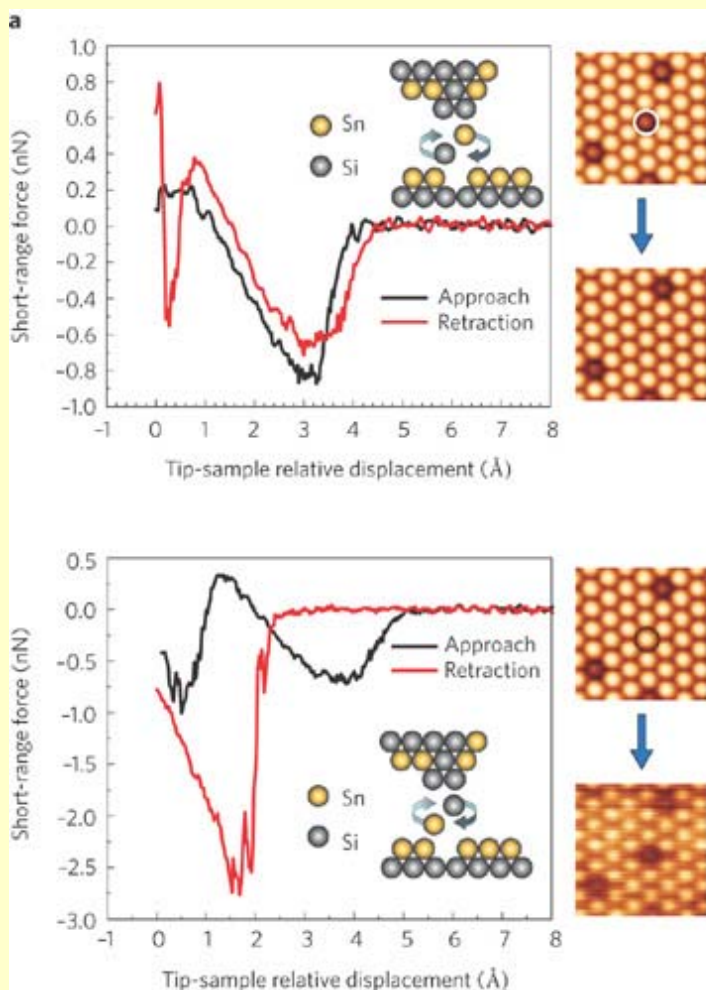
ATOMIC AND MOLECULAR MANIPULATION



STM image of atomic manipulation of iron atoms on copper(111) surface in writing Chinese characters for "atom" by C. P. Lutz and D. M. Eigler, to which the literal translation is something like "original child" (courtesy of IBM Research, Almaden Research Center)



STM image of nanoscale millennial numbers "2000" are constructed with 47 CO-molecules regulated on a Cu(211) surface using lateral manipulation at **15 K** (courtesy of Dr. Gerhard Meyer of IBM Zurich Research Laboratory, Rüschlikon, Switzerland).

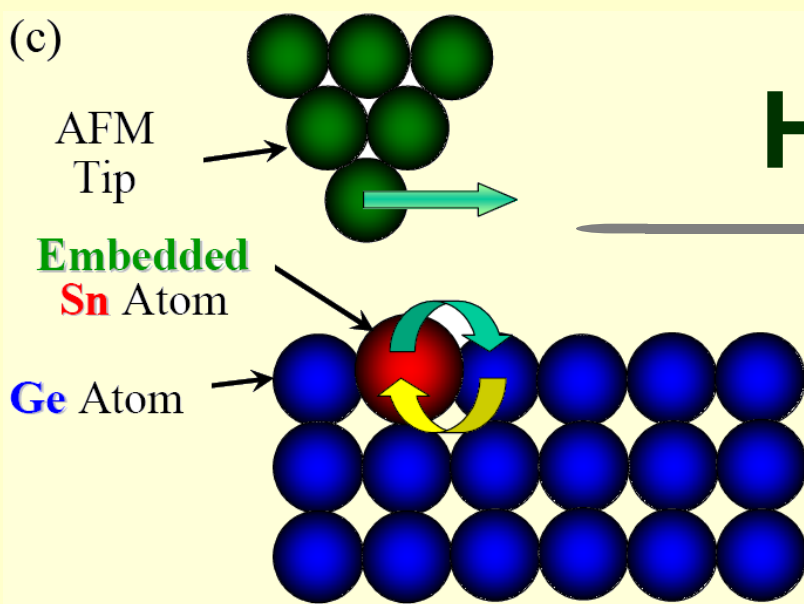


In e), silicon, tin and hydrogen atoms are represented by yellow, blue and white spheres, respectively, and the tip apex and surface models correspond to the atomic arrangements in the upper and lower halves respectively.

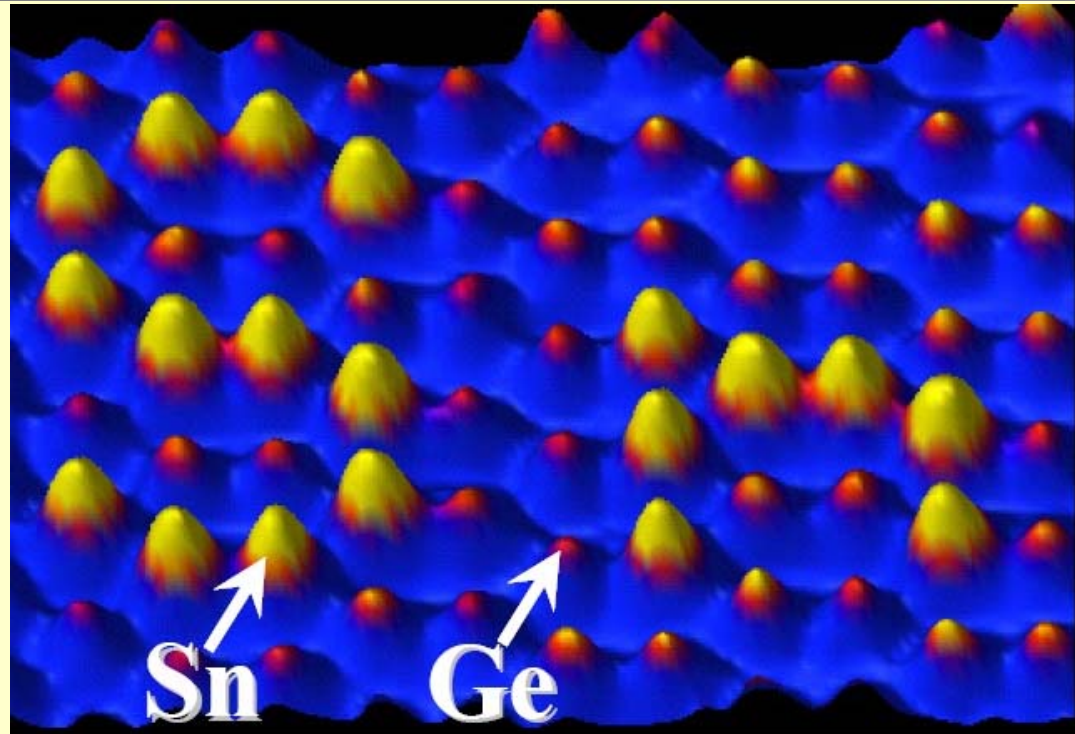
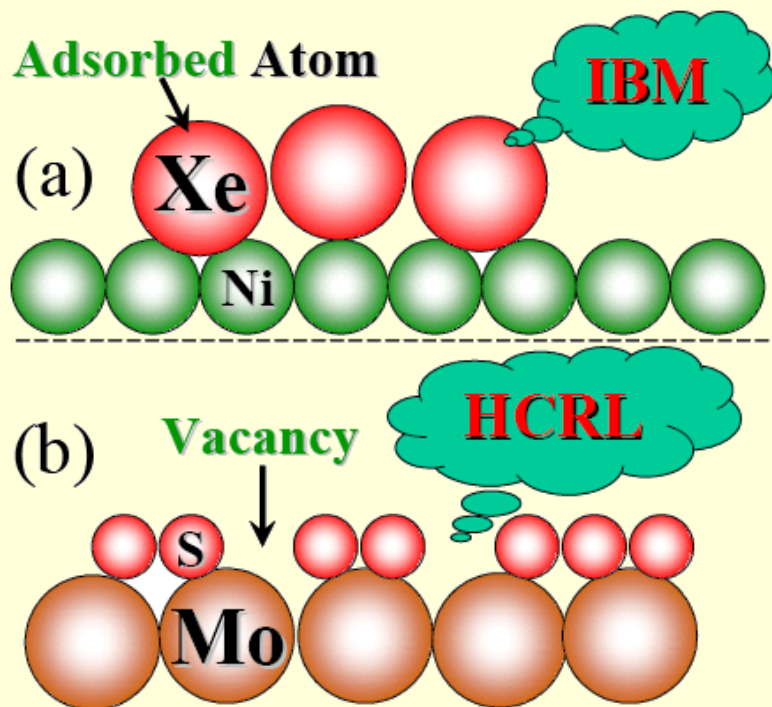
a) By gently exploring the repulsive forces of the bonding interaction between the foremost atom of the AFM tip and atoms probed at a surface, it is possible to induce the vertical interchange of the interacting atoms. Here, a Si defect of the Sn/Si(111)-(3x3)R30° surface (white circle) was replaced by a Sn atom coming from the AFM tip. In a subsequent process, the newly deposited Sn atom (dark circle) was substituted by a Si atom coming from the tip. Applying this manipulation method in heterogeneous semiconductor surfaces enables one to 'write' (b) and 'erase' (c) atomic markers by respectively depositing and removing the atoms in lower concentration (Si in the case of b and c). Reproducibility of this manipulation method provides another way to create atomic designs on surfaces with an AFM at room temperature (d). These vertical-interchange manipulations involve complex multi-atom contacts between tip and surface.

(Custance et al., Nature Nanotechnology 2009).

(c)



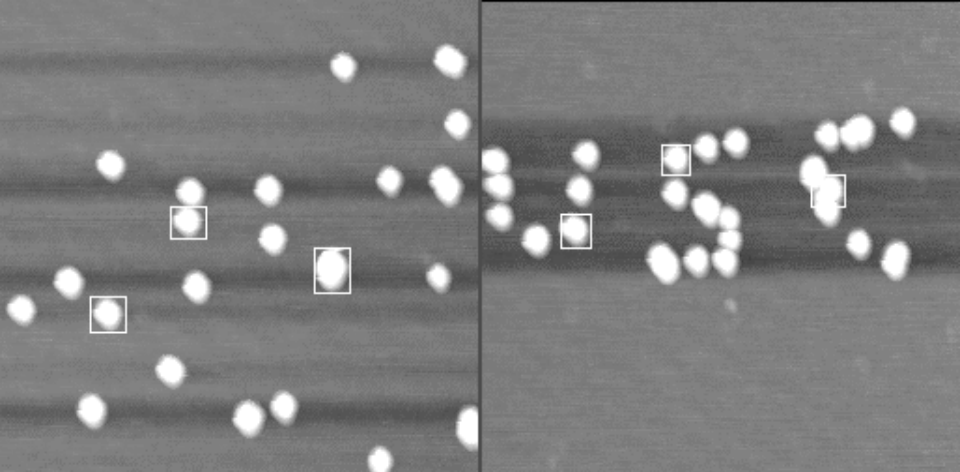
How to Move an Atom



"Atom Inlay", that is, atom letters "Sn" consisted of 19 Sn atoms embedded in Ge(111)-c(2 × 8) substrate

Sugimoto et al. Nature Mater. 4, 156-159, 2005

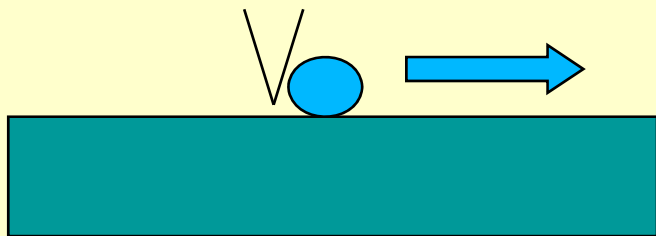
Schematic models of lateral atom manipulation (a) IBM group (STM low temperature), (b) Hitachi group (AFM low temperature), and (c) Osaka group (AFM room temperature).



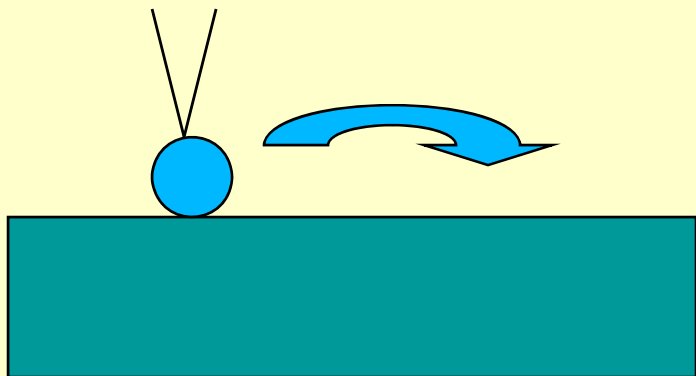
ATOMIC AND MOLECULAR MANIPULATION

(Bottom-up)

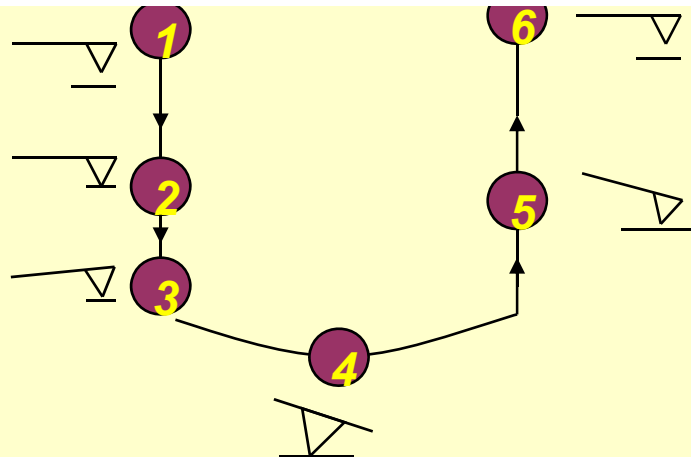
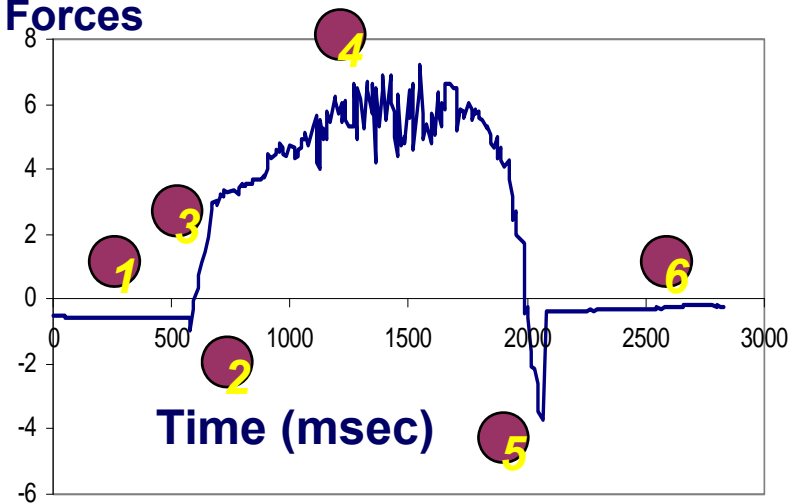
Push Objects



Lift-Drop

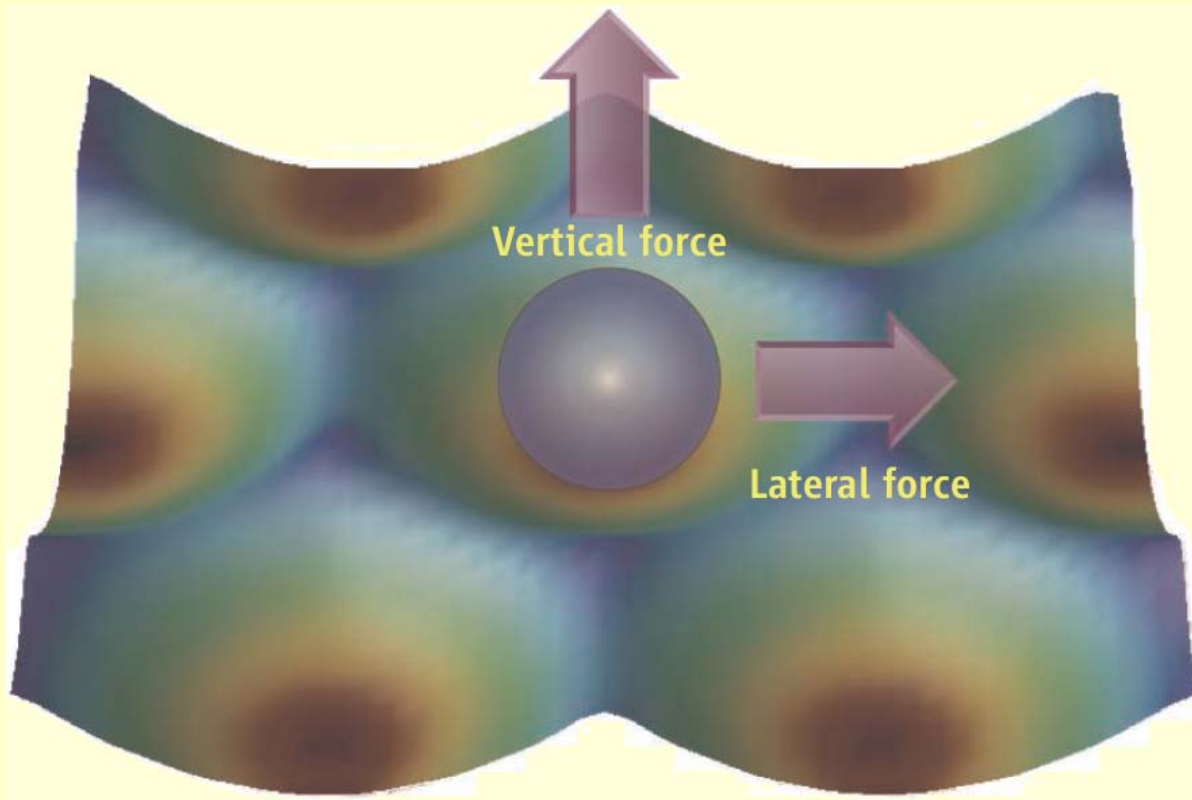


Forces



ATOMIC & MOLECULAR MANIPULATION

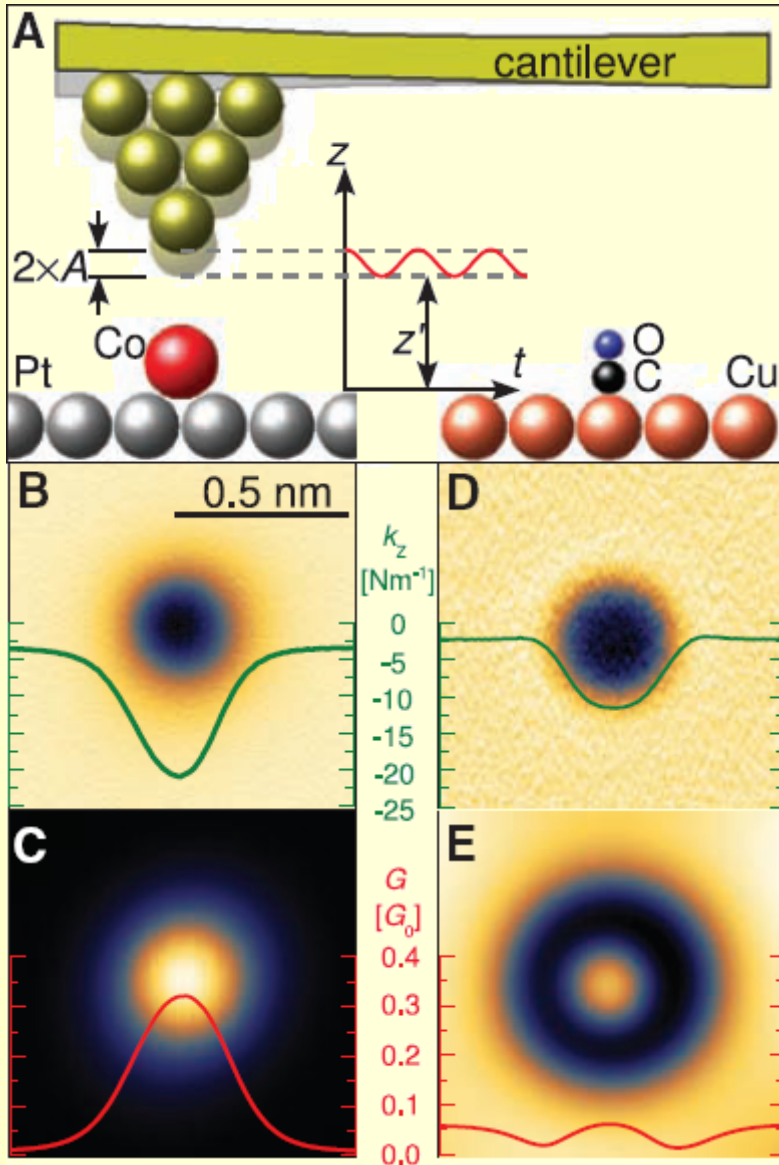
(Bottom-up)



Atomic manipulation. Using a sophisticated scanning probe implementation, Ternes *et al.* (2008) determine how much lateral and vertical force is required to pull an atom on a metallic surface and how these forces are related to each other.

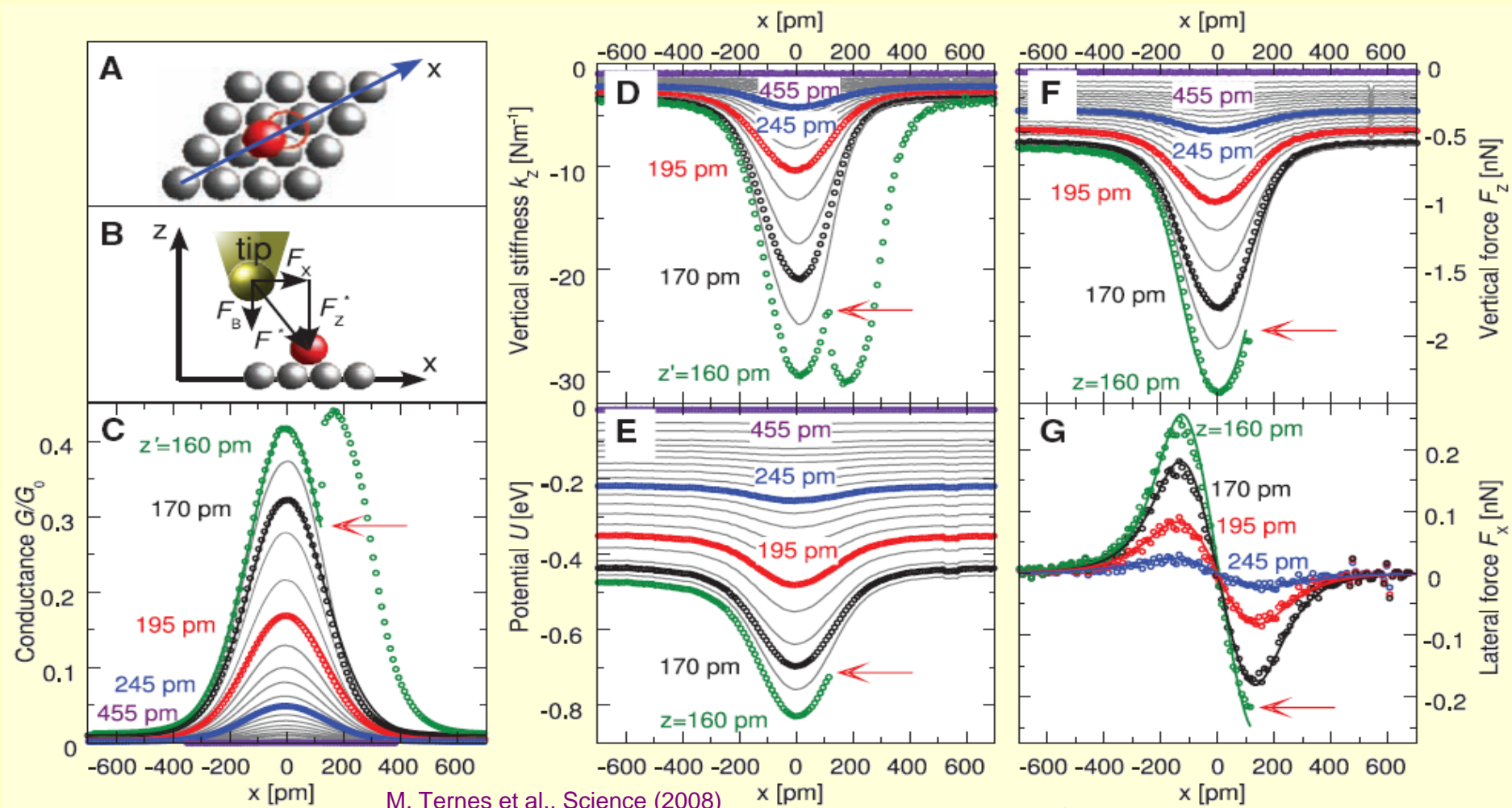
Atomic Manipulation Force Measurements

210 pN to moving Co on Pt (111) laterally & 17 pN to moving Co on Cu (111) laterally

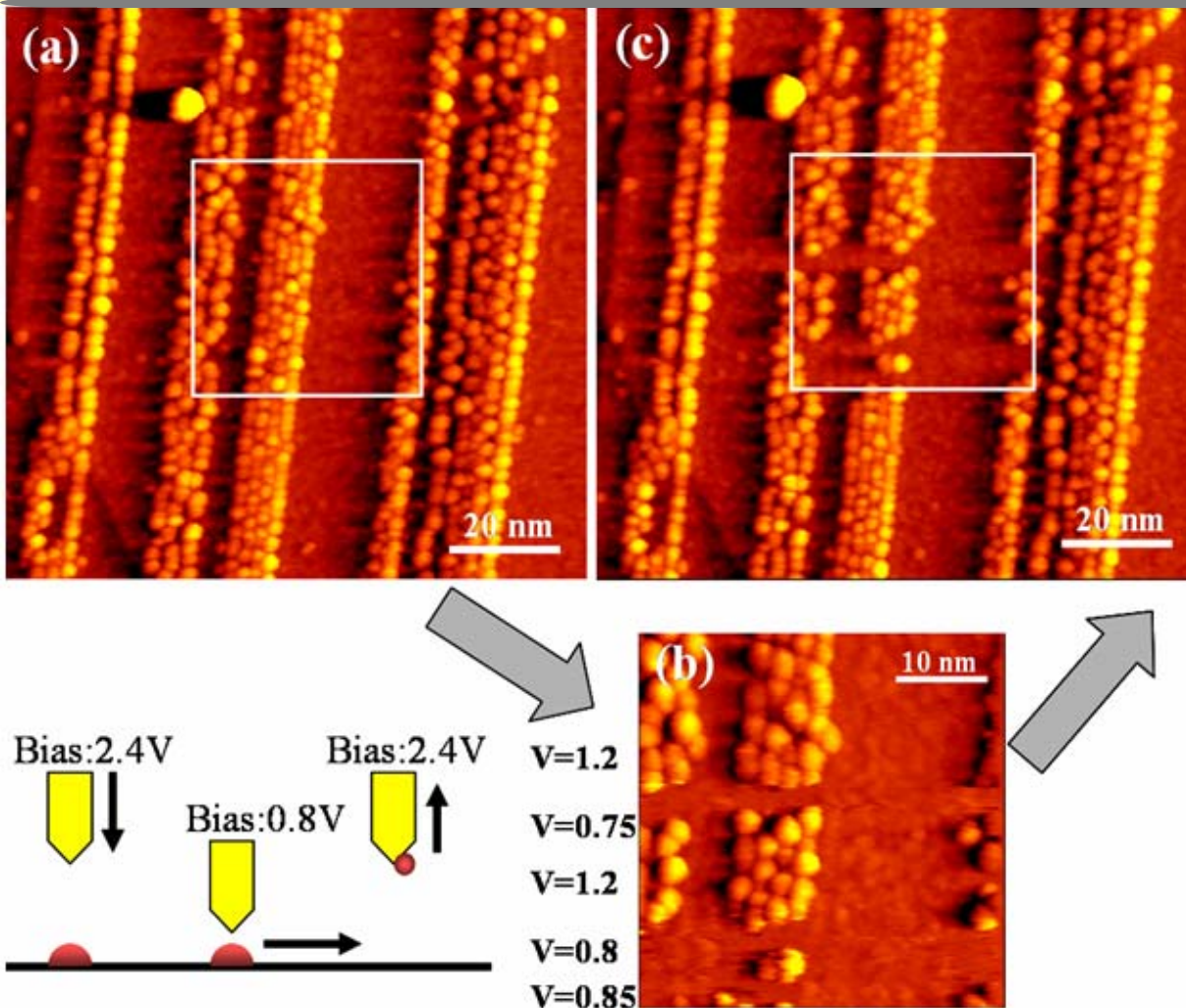


Simultaneous AFM and STM measurements of individual adsorbates: A) An atomically sharp metal tip is oscillating in z with an amplitude $A = 30 \text{ pm}$ over a flat metal surface on which an individual Co atom or CO molecule is adsorbed. The measured frequency shift of the cantilever from its natural resonance frequency is proportional to the vertical stiffness k_z of the tip-sample interaction. A small bias voltage of 1 mV was applied between tip and sample to measure the tunneling current, which is proportional to the conductance G , given in units of the single-channel, spin-degenerate quantum of conductance $G_0 = 2e^2/h = (12,906 \text{ ohm})^{-1}$, where e is the elementary charge and h is Planck's constant. The inset graph shows the tip motion $z(t)$ between its closest distance (z') and farthest distance ($z' + 2A$) from the sample. The ball models of the surfaces are scaled to match the dimensions of the images in the following panels. (B to E) Images measured at a constant height z' close to the threshold for adsorbate motion. (B) The tip-sample stiffness of a single Co atom on Pt(111). (C) Tip-sample conductance measured simultaneously for the same system as in (B). (D and E) Same as (B) and (C) for a single CO molecule on Cu(111). The colored curves in the panels are horizontal cross sections through the centers of the images.

Measuring the force to move Co on Pt(111). (A) Schematic top view of the Pt(111) surface atoms (gray) and the adsorbed Co atom (red). In the following panels, constant-height line scans in the direction of easiest adsorbate motion (x direction) were taken at successively reduced tipsample separations until the Co atom hopped to the adjacent adsorption site [red circle in (A)]. The scan speed was ~ 0.5 nm/s. (B) The force F^* between tip apex and the Co atom can be divided into the lateral force F_x and the vertical force F_z^* . The total vertical force F_z is the sum of F_z^* and the **background force F_B** (C and D). Simultaneously measured conductance G and stiffness k_z (circles and gray lines). Note that these values are time-averaged over the cantilever oscillation between $z = z'$ and $z = z' + 2A$. We label selected line scans with the closest approach z' during the oscillation. (E to G) Tip-sample interaction energy U , vertical force F_z , and lateral force F_x extracted from the stiffness k_z data in (D). Selected line scans are labeled with the tip height z ; here, the oscillation amplitude has been deconvolved from the curves. The red arrows in (C) to (G) indicate the hop of the Co atom to the neighboring binding site. Colored lines in (C), (F), and (G) are fits with the s-wave model.



MANIPULATION OF NANOCUSTERS BY STM



(c) STM image of the same surface region as in (a) after zoom out (b) scanned with same imaging parameters (2.4 V, 0.8 nA). The inset cartoon illustrates the procedure.

STM images showing removal of the Co clusters by reducing the bias during scanning. (a) STM image of Co clusters grown on ordered $\text{Al}_2\text{O}_3/\text{NiAl}(100)$ surface (bias = 2.4 V and tunneling current = 0.8 nA). (b) Zoom in the area shown by the square in (a). The bias was lowered to different values as indicated in the figure ($I = 0.8$ nA) during scanning.

Nanomanipulation: Milestones & Applications

- **1991: Single Xe atoms positioned on Ni (110) surface** (Eigler, Schweizer, [Nature](#))
- **1993: Quantum confined structures built*** (Crommie, Lutz, Eigler, [Science](#))
- **1999: Magnetic nanostructures built*** (Chen, Jamneala, Madhavan, Crommie, [Phys. Rev.](#))
- **1999: Single bonds characterization** (Lee, Ho, [Science](#))
- **2000: Artificial molecules built*** (Hla, Bartels, Meyer, Rieder, [Phys. Rev. Lett](#))
- **2000: Atomic chemical reaction *** (Hla, et al., [Phys. Rev. Lett](#))
- **2002: Atomic wire built*** (Nilius, Wallis, Ho, [Science](#))
- **2002: Molecular computation: molecular cascades** (Heinrich, Lutz, Gupta, Eigler, [Science](#))
- **2003: Single molecule device** (Nilius, Qiu, Ho, [Science](#))
- **2004: Single molecule doping** (Yamachika, et al., [Science](#))
- **2005: Moving atom at room temperature** (Sugimoto, et al., [Nature Mater](#))
- **2007: Chemical identification of single atoms** (Sugimoto, et al., [Nature](#))
- **2008: Force measurements in moving atoms** (Ternes, et al., [Science](#))
- **2009: Quantum confinement of electrons in 3D** (Moon et al., [Nature Nanotech](#))

* One atom at a time

Equipment to Have Precision of ~ 1 nm

- **Develop closed-loop control strategy to reduce the geometric errors induced by equipment including hysteresis creep by piezo scanner, AFM tip, mechanical drift, thermal drift....,**
 - **To reduce the hysteresis creep, feedback signal uses direct-measuring, non-contact capacitive position sensors (high motion linearity, long-term stability, phase fidelity)**
 - **To reduce mechanical drift, positioning and scanning use frictionless flexure guidance (within 0.01 nm/s)**
 - **To reduce thermal drift, invar or low thermal expansion materials is used for the stage (within 0.01 nm/s)**
 - **The total inaccuracy should be less than 1 nm/mm and 0.01 nm/s.**

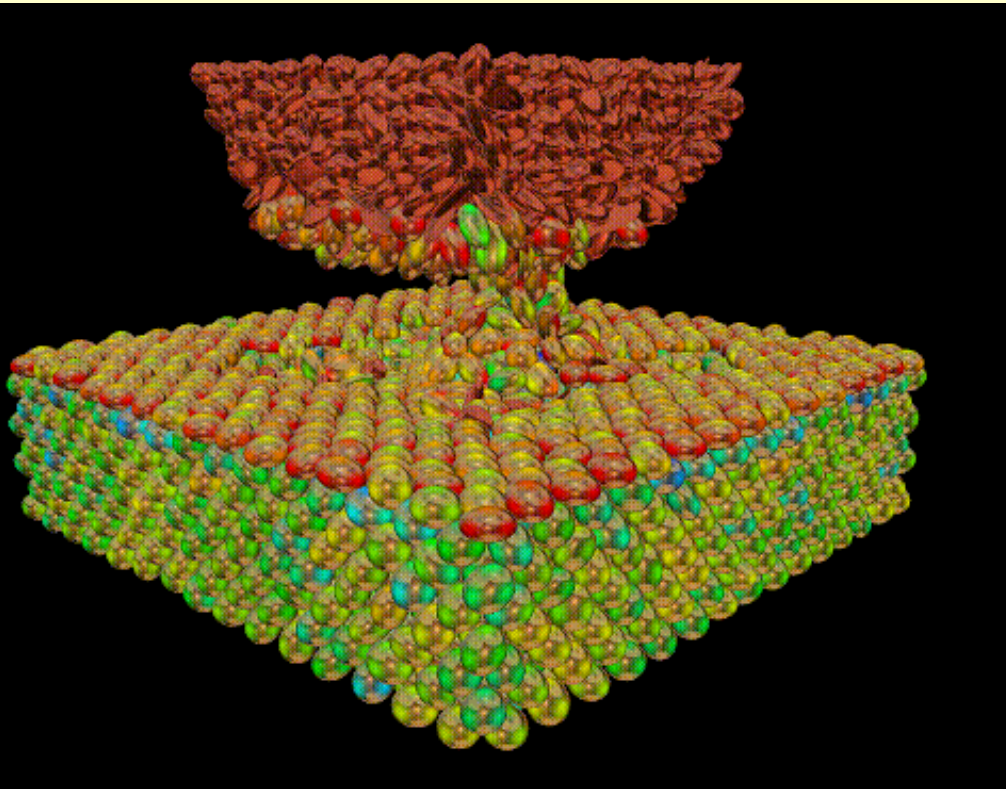
DESIGN SOFTWARE FOR PRECISION PATTERNING

- **Dimension and accuracy of patterns are highly affected by operating parameters: contact mode, tip material, scanning speed, humidity, applied voltage....**
- **Accuracy of patterning scheme requires further refining, and better processing procedures need to be developed.**
- **Height and width modulation by adjusting the phase and the duration time of pulsed voltage (short pulse voltage restricting lateral diffusion while high voltage pulse producing fast growing in height).**
- **Develop CAD software for the design and control of AFM (including DPN, STM, SNOM) oxidation and scratching patterning.**

MOLECULAR DYNAMICS SIMULATION

In general, atomistic molecular mechanics methods have the following properties:

- ▲ Each atom is simulated as a single particle
- ▲ Each particle is assigned a radius (typically the van der Waals radius), polarizability, and a constant net charge (generally derived from quantum calculations and/or experiment)
- ▲ Bonded interactions are treated as "springs" with an equilibrium distance equal to the experimental or calculated bond length



A scene from a molecular dynamics simulation of an atomic force microscope. Here a hard nickel tip comes down to a soft gold substrate. Before the tip can touch, the surface gold atoms jump up and coat the tip, leaving a neck of gold joining the surface with the tip. Elongation of the atomic spheres and spot coloring are used to indicate elongation/compressive and shear forces.